EUROPEAN PATENT SPECIFICATION

Date of publication of patent specification: 04.01.95

Int. Cl.\textsuperscript{f}: C23C 16/32, C23C 16/08, C23C 16/52

Application number: 88113932.3

Date of filing: 26.08.88

High hardness fine grained tungsten-carbon alloys and process for making same.

Priority: 03.09.87 US 92809

Date of publication of application: 08.03.89 Bulletin 99/10

Publication of the grant of the patent: 04.01.95 Bulletin 95/01

Designated Contracting States: AT BE CH DE FR GB IT LI LU NL SE

References cited:
- GB-A- 1 326 769
- GB-A- 1 540 718
- US-A- 4 162 345

Proprietor: AIR PRODUCTS AND CHEMICALS, INC.
P.O. Box 538
Allentown, Pennsylvania 18105 (US)

Inventor: Garg, Diwakar
2815 Whitemarsh Place
Macungie, PA 18062 (US)
Inventor: Kluchcr, Beth A.
4501 Cedros Ave.Apt.309
Sherman Oaks, CA 91403 (US)
Inventor: Dyer, Paul Nigel
3920 Pleasant Ave.
Allentown, PA 18103 (US)
Inventor: Kidd, Richard W.
24542 Burr Court
Newhall, CA 91321 (US)
Inventor: Ceccarelli, Christopher
Spring Ridge C17
13th and Fairmont Streets
Whitehall, PA 18052 (US)

Representative: Kador & Partner
Corneliusstrasse 15
D-80469 München (DE)

Note: Within nine months from the publication of the mention of the grant of the European patent, any person may give notice to the European Patent Office of opposition to the European patent granted. Notice of opposition shall be filed in a written reasoned statement. It shall not be deemed to have been filed until the opposition fee has been paid (Art. 99(1) European patent convention).
Description

Field of the Invention

This invention relates to high hardness fine grained tungsten-carbon alloys and to a process for producing the same.

Background of the Invention

High hardness materials are widely used as coatings on various types of mechanical components and cutting tools. Such coatings impart wear and erosion resistance and thus increase the wear and erosion life of objects that have been coated. The high hardness materials can also be used to produce free standing objects which are wear resistant.

Chemical vapor deposition processes can be used to produce high hardness coatings and high hardness free standing objects. In a typical chemical vapor deposition (CVD) process the substrate to be coated is heated in a suitable chamber and then a gaseous reactant mixture is introduced into the chamber. The gaseous reactant mixture reacts at the surface of the substrate to form a coherent layer of the desired coating. By varying the gaseous reactant mixture and the CVD process parameters, various types of deposited coatings can be produced.

Deposits produced by chemical vapor deposition, both for coating substrates and for producing free standing objects, have suffered certain drawbacks. Although the hardness of the deposits has been satisfactory, the strength and toughness of the materials has often been lower than desired. This lack of strength and toughness is due in large part to the grain size, crystallite size, and structure of the compounds that make up the deposit. Unfortunately, regardless of the components of the gaseous reactant mixture, typical CVD techniques produce coatings having relatively large grains which are arranged in columns. Thus, cross-sectional metallographic examination of a typical chemical vapor deposition deposit will show grains usually in excess of several microns in size which are arranged in columns that extend perpendicularly to the substrate surface. Such deposits are typically quite brittle since adjacent columns of grains result in long interstitial regions of weakness. Such regions are easily fractured and attacked by corrosive agents and erosive media. Because of the columnar grain structure, such deposits also have poor surface finish and poor wear and erosion resistance properties.

US-A-4 162 345 discloses a method for producing deposits of tungsten and carbon or molybdenum and carbon which results in deposits characterized by a structure which is free of columnar grains and instead consists essentially of fine, equiaxial grains. These deposits have unusually high hardness and tensile strength. US-A-4 162 345 discloses use of temperatures varying from 650 °C to 1,100 °C, which are high enough to severely degrade the mechanical properties of various carbon steels, stainless steels, nickel alloys, titanium alloys and cemented carbide.

In the method of US-A-4 162 345, a sequence of events is made to take place which, although similar to conventional chemical vapor deposition, is not truly that. The method employs a reactor which is essentially similar to a chemical vapor deposition reactor. However, according to the method of US-A-4 162 345 the apparatus is operated in such a manner that the typical chemical vapor deposition process does not take place. Typical chemical vapor deposition involves a single reaction by the gases in the reactor at the surface of the substrate resulting in the formation of a solid phase deposit directly on the substrate surface. On the other hand, US-A-4 162 345 describes a deposition process involving at least two distinct reaction steps. According to the method of US-A-4 162 345, an initial reaction is caused to take place displaced from the surface of the substrate. This reaction involves a decomposition or partial reduction of a fluoride of tungsten (preferably WF₆) by a substitution reaction with an oxygen or oxygen-containing group derived from a gaseous organic compound containing hydrogen, carbon and oxygen. Subsequent reaction with hydrogen gas results in the formation of the final deposits. The material of US-A-4 162 345 is a hard metal alloy, consisting primarily of tungsten and carbon. X-ray diffraction analysis of the alloy shows that the deposit is akin to tungsten but with a very finely dispersed carbide, probably in the form WC.

US-A-4 427 445 also discloses a hard fine grained material which can be produced by thermochemical deposition, but at temperatures lower than those described in the examples of US-A-4 162 345. Thus, where there are large differences in the thermal coefficients of expansion between the substrate material and the coating material, the methodology of US-A-4 427 445 reduces adhesion problems and problems associated with mechanical distortion, metallurgical transformation or stress relief of the substrate. The material of US-A-4 427 445 is a tungsten carbon alloy consisting primarily of a two phase mixture of substantially pure tungsten and an A18 structure.
U.S. Patent 3,388,914, discloses a process for adherently depositing tungsten carbide of substantial thickness on steel and other metal substrates. The process involves first diffusing another metal on the surface of the substrate to relax the thermal expansion coefficient zone of the metal substrate. The carbide coating is then deposited on the diffused surface by CVD. The process claims it is preferable to diffuse the metal forming the carbide into the substrate. In one embodiment of the claimed process, a thin layer of W is deposited on the metal surface using 600-1000 °C temperature. After coating W, the temperature is increased to approximately 1000-1200 °C and held there for a significant period of time to permit diffusion of W into the metal. The diffused surface is then coated with tungsten carbide using WF₆, CO and H₂. In the alternative embodiment, a pack diffusion technique is used for achieving diffusion of W into metal. Temperature ranging from 1000-1200 °C is used in the pack diffusion step. The diffused metal surface is then coated with tungsten carbide.

US-A-3 389 977 discloses a method of depositing substantial pure tungsten carbide in the form of W₂C, free from any metal phase. Pure W₂C is deposited on a substrate by reacting WF₆ and CO. The substrate is heated to a temperature in excess of 400 °C. The adherence of W₂C to steel is improved by first cleaning the surface and then depositing with a thin film of W followed by W₂C using a temperature ranging from 600-1000 °C. Since initial deposition of tungsten is conducted at or above 600 °C, the process of US-A-3 389 977 is not feasible for providing erosion and wear resistance coating on various carbon steels, stainless steels, nickel and titanium alloys without severely degrading their mechanical properties. Additionally pure W₂C deposited according to the teachings of US-A-3 389 977 consists of columnar grains. US-A-3 389 977 does not describe a process for depositing W₂C coating in non-columnar fashion.

U.S. Patent 3,574,672 discloses a process for depositing W₂C by heating a substrate to a temperature between 400-1300 °C. The process described in this patent is essentially the same as disclosed in U.S. Patent 3,389,977.

U.S. Patent 3,721,577 discloses a process for depositing refractory metal or metal carbides on ferrous and non-ferrous base materials heated to at least 1050 °C. The metal carbides are deposited using halide vapors of the metal along with methane and hydrogen.

US-A-3 814 625 discloses a process for the formation of tungsten and molybdenum carbide by reacting a mixture of WF₆ or MoF₆, benzene, toluene or xylene and hydrogen. The process is carried out under atmospheric pressure and temperatures ranging from 400-1000 °C. An atomic ratio of W/C in the gaseous mixture varying from 1 to 2 is required to yield W₂C. The process also suggests that for some substrates such as mild steel, it is advantageous in providing better adhesion to deposit a layer of nickel or cobalt prior to tungsten carbide deposition. The process also claims the formation of a mixture of tungsten and tungsten carbide in the presence of large proportions of free hydrogen. The mixture of W and W₂C coating deposited according to the teaching of US-A-3 814 625 consists of columnar grains. US-A-3 814 625 does not disclose a process for depositing a mixture of W and W₂C in non-columnar fashion.

British Patent 1,326,780 discloses a method for the formation of tungsten carbide by reacting a mixture of WF₆, benzene, toluene or xylene and hydrogen under atmospheric pressure and temperatures ranging from 400-1000 °C. The process disclosed in this patent is essentially the same as disclosed in U.S. Patent 3,814,625.

British Patent 1,540,718 discloses a process for the formation of W₂C using a mixture of WF₆, benzene, toluene or xylene and hydrogen under sub-atmospheric pressure and temperature ranging from 350-500 °C. An atomic ratio of W/C in the gaseous mixture varying from 3-6 is required to yield W₂C. The coating deposited according to the teaching of British Patent 1,540,718 consists of columnar grains. The British patent 1 540 718 does not teach a process for depositing a non-columnar coating.

Although the methods of the Holzl patents cited above have been useful in producing fine-grained tungsten/carbon alloys containing mixtures of W and WC, and W and A15 structure, and the methods described in other cited patents have been successful in producing columnar WC or W₂C or mixtures of W and WC, no one has yet disclosed a method for producing extremely hard, fine-grained and non-columnar tungsten-carbon alloys containing mixtures of tungsten and true carbides in the form of W₂C or WC or a mixture of W₂C and WC. Such alloys would be especially useful since the presence of the W₂C and/or W₂C carbides in non-columnar microstructure would contribute to both the hardness and the tensile strength of the deposited materials.

Figures

Figure 1 is a photomicrograph of an etched cross-section of tungsten coating on AM-350 stainless steel. Figure 2 is a photomicrograph of the surface of AM-350 stainless steel coated with tungsten. Figure 3 is an etched cross-sectional photomicrograph of W+W₂C coating on AM-350 stainless steel.
Figure 4 is a photomicrograph of the surface of AM-350 stainless steel coated with W + W_2C.
Figure 5 is an etched cross-sectional photomicrograph of W + W_2C coating on SiC-B graphite.
Figure 6 is an etched cross-sectional photomicrograph of W + W_2C + W_2C coating on AM-350 stainless steel.
Figure 7 is a photomicrograph of the surface of AM-350 stainless steel coated with W + W_2C + W_2C.
Figure 8A is an unetched cross-sectional photomicrograph of W + W_2C coating on AM-350 stainless steel.
Figure 8B is an etched cross-sectional photomicrograph of W + W_2C coating on AM-350 stainless steel.
Figure 9 is a photomicrograph of the surface of AM-350 stainless steel coated with W + W_2C.
Figure 10 is a graph showing the relationship between reaction temperature and WF_6/DME ratio.
Figure 11 is an x-ray diffraction scan of a sample containing W, W_2C and W_2C phases.
Figure 12 is an x-ray diffraction scan of a sample containing W, W_2C and a trace amount of W_2C phases.
Figure 13 is an x-ray diffraction scan of a sample containing W, W_2C and a trace amount of W_2C phases.
Figure 14 is an x-ray diffraction scan of a sample containing W and W_2C phases.
Figure 15 is an x-ray diffraction scan of a sample containing W + W_2C phases.
Figures 8A, 8B, 9 and 14 are illustrative of alloys in accordance with the invention.

Summary of the Invention

The invention discloses hard, fine-grained, non-columnar, substantially lamellar tungsten-carbon alloys consisting essentially of a mixture of a substantially pure tungsten phase and a carbide phase, wherein the carbide phase is W_2C. The alloys are deposited thermochemically on a substrate, suitably under sub-atmospheric pressure to slightly atmospheric, i.e. within the range of about 133.3 Pa to about 133.3 kPa (about 1 Torr to about 1000 Torr), at a temperature of about 300°C to about 650°C, using a mixture of process gases comprising tungsten hexafluoride, hydrogen, and an oxygen- and hydrogen-containing organic compound.

Tungsten carbon alloys containing W + W_2C can be formed using a wide range of process conditions. In addition the microstructure, composition, properties, and crystallite size of the new alloys can be controlled by manipulating the process parameters used to make the alloys. More specifically, by conjunctively controlling various interdependent operating parameters, especially the reaction temperature within the range of about 300°C to about 650°C, the feed rate of tungsten halide to the oxygen- and hydrogen-containing organic compound to control the W/C atomic ratio within the range from about 1 to about 3.5, and the ratio of hydrogen to tungsten hexafluoride to more than a stoichiometric amount required from the reduction of tungsten halide, namely within the range of about 4 to about 20, and preferably within the range of about 5 to about 10, it is possible to produce a tungsten carbide alloy containing a carbide phase consisting of W + W_2C. Regardless of the composition of the carbide phase, according to the method of the invention, the reaction mixture contains more than a stoichiometric amount of H_2 required for reduction of the tungsten halide to produce W + W_2C.

The new tungsten carbon alloys of the present invention consist of a mixture of W + W_2C. These alloys are unexpectedly found to have non-columnar grains and a lamellar microstructure. The new alloys' hardness values can be manipulated by altering process conditions.

Detailed Description of the Invention

The present invention discloses new non-columnar tungsten carbon alloys consisting essentially of a mixture of a substantially pure tungsten phase and a carbide phase wherein the carbide phase is comprised of W_2C. Unlike alloys of the prior art that are produced by conventional vapor deposition techniques, the tungsten carbon alloys of the present invention are comprised of extremely fine equiaxial grains which average about one micrometer or less in size. In cross-section, the alloys of the present invention exhibit a well defined lamellar microstructure with layers less than about 2 micrometers thick. The alloys of the invention are essentially free of columnar grains and thus are more resistant to corrosion, wear and erosion than are prior art alloys composed of columnar grains.

The method of the present invention is based on the surprising discovery that deposits consisting of a mixture of a substantially pure tungsten phase and a carbide phase, consisting of W_2C, in a fine grain, non-columnar microstructure can be produced by not only controlling the temperature of the reaction but also by controlling the W/C atomic ratio and the ratio of the hydrogen to tungsten halide which takes place in the
initial tungsten halide substitution reaction. Since the various operating parameters can be interdependent, the operating parameters should be conjunctively controlled. As used herein the term "conjunctively controlled" means that the operating parameters as whole are controlled; in other words, the effect of a change in one parameter will be used in determining the operating values for the remaining parameters. For example, a change in the reaction temperature may necessitate a change in the ratio of tungsten halide to the oxygen- and hydrogen-containing organic compound.

By carefully selecting appropriate combinations of reaction temperature, the W/C atomic ratio and the ratio of hydrogen to tungsten halide, the composition of the carbide phase and the characteristics of the tungsten carbon alloy can be controlled. Additional refinement of the carbide phase can be made by producing the alloys in the presence or absence of a diluent or inert gas such as argon, nitrogen and helium. For example, Figure 10 is a graphic representation of the processing and compositional data from Examples 3A-H through 5A-U, as tabulated in Tables 1 and 2. Using that data as guidelines, if one wishes to produce a tungsten carbon alloy having a carbide phase consisting of W<sub>2</sub>C and lamellar microstructure, this alloy can be produced at a reaction temperature ranging from 375 °C - 475 °C, using dimethylether (DME) as an oxygen- and hydrogen-containing organic compound with WF<sub>6</sub> as the tungsten halide and a H<sub>2</sub>/WF<sub>6</sub> ratio of about 10.

Using the teaching of the present invention, it will be readily apparent to those skilled in the art that, in these new tungsten carbon alloys, the composition of the carbide phase can be manipulated by changing, in a conjunctively controlled manner, the reaction temperature, the W/C atomic ratio, and the ratio of hydrogen to tungsten halide. Using the teaching of the present invention, such routine alteration of process parameters is now well within the skill of one skilled in the art, making it possible to utilize the broad teaching of the present invention to create custom tungsten carbon alloys having desired compositions and characteristics.

Turning now to preferred process conditions for making the tungsten carbon alloys of the present invention, with regard to pressure within the reaction vessel, preferred pressure is usually sub-atmospheric, down to 133.3 Pa (1 Torr), or up to slightly above atmospheric pressure, 1,33 x 10<sup>5</sup> Pa (1000 Torr).

With regard to the reaction temperature, temperatures of about 300 °C to about 650 °C are preferred; temperatures in the range of about 400 °C to about 450 °C are especially preferred.

With regard to the hydrogen gas component of the reaction mixture, it is essential for the deposition of the alloys to use more than a stoichiometric amount of hydrogen required for complete conversion of the tungsten fluoride (e.g., WF<sub>6</sub>) to hydrogen fluoride (HF).

With regard to the oxygen- and hydrogen-containing organic compound, preferred compounds are selected from group consisting of C<sub>1</sub>-C<sub>4</sub> alcohols and aldehydes, C<sub>2</sub>-C<sub>4</sub> ethers, epoxides and ketenes and C<sub>2</sub>-C<sub>4</sub> ketones, For example, methanol, formaldehyde, ethanol, dimethyl ether, ketene (carbomethane), acetaldehyde, ethylene oxide, vinyl alcohol, acetone, acrolein, allyl alcohol, methyl ethyl ether, isopropyl alcohol, n-propyl alcohol, propylene oxide, propene oxide, propionaldehyde, propionaldehyde, 2-propyne-1-ol, 3-methoxy propyne, vinyl ether, ethyldi ether, furan, tetrahydrofuran, crotonaldehyde, and α-methyl acrolein. Especially preferred is the two carbon and one oxygen-containing organic compound, dimethyl ether (DME).

Due to the interdependency of the various operating parameters it is to be expected that the operating range of the tungsten halide to oxygen-and hydrogen-containing organic compound ratio or W/C atomic ratio may change depending on the number of carbon atoms in the oxygen- and hydrogen-containing organic compound. For example, use of a compound such as methanol, with one carbon atom, would be expected to reduce the operating range of the tungsten halide to methanol ratio. On the other hand, use of a compound such as diethyl ether, which has four carbons, would be expected to increase the operating range of the tungsten halide to diethyl ether ratio.

The tungsten/carbon alloys of the present invention can be deposited on a number of ferrous metals and alloys such as cast iron, carbon steels, stainless steels and high speed steels, non-ferrous metals and alloys such as copper, nickel, platinum, rhodium, titanium, aluminum, silver, gold, niobium, molybdenum, cobalt, tungsten, rhenium, copper alloys, nickel alloys such as inconel and monel, titanium alloys such as Ti/Al/V, Ti/Al/Sn, Ti/Al/Mo/V, Ti/Al/Sn/Zr/Mo, Ti/Al/V/Cr, Ti/Mo/V/Fe/Al, Ti/Al/V/Cr/Mo/Zr and Ti/Al/V/Sn alloys, non-metals such as graphite, carbides such as cemented carbide, and ceramics such as silicon carbide, silicon nitride, alumina, etc. In depositing tungsten carbon alloys of the present invention on reactive substrate materials, such as cast irons, carbon steels, stainless steels, high speed steels, titanium and titanium alloys, aluminum and aluminum alloys, and nickel alloys, it is preferred to coat the substrate first with a more noble material such as nickel, cobalt, copper, silver, gold, platinum, palladium or iridium, by electrochemical or electroleochniques or by physical vapor deposition such as sputtering. However, no deposition of noble material is required for coating non-reactive materials such as copper, nickel, cobalt,
silver, gold, platinum, rhodium, niobium, molybdenum, tungsten, rhenium, graphite, carbides and ceramics. Free standing parts of tungsten/carbon alloys of the present invention can be made by depositing the alloy on substrates such as copper, nickel, cobalt, silver, gold, molybdenum, rhenium, and graphite and then removing these substrates by grinding and chemical or electrochemical etching.

The deposits of the present invention are comprised of mixtures of W + W2C, W + W2C, and W + W2C + W2C. The deposits are characterized by a non-columnar crystal or grain structure consisting essentially of homogeneous fine and equiaxial grains having an average crystallite size of less than about 0.1 μm (microns). This is in contrast to the typical columnar crystal habit of conventional chemical vapor deposition. Deposits made by the method of the present invention are essentially lamellar and have been found to have unusually high wear and erosion resistance and unexpected hardness.

The Examples which follow illustrate the wide range of operating parameters which can be used to create "customized" alloys having desired compositions and characteristics. As a control, Examples 1 and 2 illustrate production of prior art tungsten consisting of columnar grains. The non-columnar grain containing alloys of the present invention are illustrated in Examples 3-5. More specifically, Examples 3A-I illustrate production of tungsten carbon alloys having a carbide phase consisting of W2C, i.e., a tungsten carbon alloy consisting of W + W2C. Examples 4A-N illustrate production of tungsten carbon alloys having a carbide phase consisting of W2C + W2C, i.e., a tungsten carbon alloy consisting of W + W2C + W2C. Examples 5A-Z illustrate production of alloys having a carbide phase consisting of W2C, i.e., a tungsten carbon alloy consisting of W + W2C. The data in Examples 5Q to 5X also illustrate that a diluent such as argon can be used during the coating reaction to affect coating hardness without concomitantly affecting coating composition or crystallite size. The date in Examples 3I, 4L to 4N, and 5X to 5Z illustrate the effect of using different hydrogen to WF6 ratio on coating composition. Example 6 illustrates that tungsten/carbon alloys can be deposited on cemented carbide without a protective layer of noble material. Examples 7 and 8 illustrate that tungsten/carbon alloys can be deposited on aluminum and titanium alloys with protective layer of noble materials. Example 9 illustrates the ceramic materials such as alumina can be deposited with tungsten/carbon alloys without a protective layer of noble materials. Examples 10 and 11 show that tungsten/carbon alloys can be deposited on molybdenum. Example 12 shows that a tungsten followed by tungsten/carbon alloy coatings can be deposited on various metals and alloys. Example 13 illustrates the erosion performance of some of the alloys of the present invention. Examples 14 and 15 illustrate the wear performance of tungsten/carbon alloy (W + W2C) of the present invention. Finally, Examples 16 to 20 illustrate that several different oxygen-and-hydrogen containing organic compounds can be used to produce tungsten/carbon alloys.

Using the preferred tungsten halide, tungsten hexafluoride (WF6), and the preferred oxygen- and hydrogen-containing organic compound, dimethyl ether (DME), the Examples also illustrate the best mode of making and using the present invention.

EXAMPLES FOR TUNGSTEN COATING

Example 1

Two 0.24 x 2.54 x 5.08 cm (0.095 inch x 1 inch x 2 inch) SiC-6 graphite and three AM-350 stainless steel specimens were placed in an inductively heated graphite furnace inside a gas-tight quartz envelope. Stainless steel specimens were electroplated with 3-5 μm thick nickel before coating operation to protect them from the attack of corrosive HF gas. The specimens were heated to 443°C and a gaseous mixture of 300 cm³/min of WF6 and 3,000 cm³/min of hydrogen was passed into the furnace over the specimens. The total pressure within the system was maintained at 5332 Pa (40 Torr). The deposition was conducted for 40 minutes; thereafter, the flow of the reactive gases was stopped and the specimens were cooled.

The specimens were found to be coated with a dull, adherent, coherent, and non-uniform coating of 12 to 50 micrometers thick tungsten on each side (see Tables 1 and 2). The coating consisted of columnar grains as shown in Figure 1. The coating had a very rough surface finish as shown in Figure 2. The average surface finish of uncoated AM-350 stainless steel was 0.04 cm (16 micro-inch); whereas, the average surface finish of the coated specimen was 0.09 cm (36 micro-inch). This indicated that the coating degraded the surface finish of the specimen. The coating had a hardness of 510 and 465 Vickers on graphite and stainless steel specimens, respectively.
Example 2

A number of AM-350 and SS-422 stainless steel and IN-718 0.24 x 2.54 x 5.08 cm specimens (0.095 inch x 1 inch x 2 inch) electroplated with 3-4 μm thick layer of either nickel or copper using electrolytic technique were placed in the furnace similar to that described in Example 1. The specimens were heated to 443 °C and a gaseous mixture of 300 cm³/min of WF₆, 3,000 cm³/min of hydrogen, and 4,000 cm³/min of argon was passed into the furnace over the specimens. The total pressure within the system was the same as in Example 1. The deposition, however, was conducted only for 15 minutes; thereafter, the flow of the reactive gases was stopped and the specimens were cooled.

All the specimens were coated with a dull, adherent, coherent, and uniform coating of 10-12 μm thick tungsten on each side. The coating consisted of columnar grains and had rough surface finish. The average surface finish of the uncoated AM-350 stainless steel was 0.04 cm (16 micro-inch); whereas, the average surface finish of the coated specimen was 0.046 cm (18 micro-inch). This indicated that the degradation of surface finish by tungsten coating could be controlled by carefully selecting the process conditions. The hardness of tungsten coating varied between 455 to 564 Vickers, as shown in Table 1.

This Example shows that both nickel and copper interlayers can be used to protect the reactive substrate from the attack of hot HF gas.

EXAMPLES FOR TUNGSTEN CARBON ALLOY (W + W₃C) COATING

Example 3A

In this Example, several specimens of SiC-6 graphite and nickel plated AM-350 stainless steel were coated simultaneously in a single run. All the specimens were 0.24 x 2.54 x 5.08 cm (0.093 inches thick, 1 inch wide, and 2 inches long). The specimens were heated to a temperature of about 440 °C and a gaseous mixture of 300 cm³/min WF₆, 3,000 cm³/min of hydrogen and 40 cm³/min of DME was passed into the furnace over the specimens. A WF₆/DME ratio of 7.5 or W/C atomic ratio of 3.75 and a H₂/ WF₆ ratio of 10.0 were maintained throughout the run. The total pressure was maintained at 5332 Pa (40 Torr), to provide a DME partial pressure of 64 Pa (0.48 Torr), as shown in Table 1. The deposition was conducted for 30 minutes.

The graphite and stainless steel specimens were coated with a bright smooth, adherent, coherent, and uniform coating. The coating thickness on stainless steel specimens was ~22 micrometer. The coating on both graphite and stainless steel specimens was free of columnar grains as shown in Figure 3. The dark areas in the etched cross-section of the coating showed areas rich in W₃C, indicating non-uniform distribution of W and W₃C in the coating. The coating had a smooth surface finish as shown in Figure 4. The average surface finish of the uncoated AM-350 stainless steel was 0.04 cm (16 micro-inch), whereas, the average surface finish of the coated specimen was 0.018 cm (7 micro-inch). This indicated that the coating improved the surface finish of the specimen. The composition of the coating was determined by X-ray diffraction. It consisted of a mixture of W and W₃C phases (see Table 2).

Example 3B

The CVD run described in Example 3A was repeated with the exceptions of using 30 minutes reaction time instead of 40 minutes and 442 °C reaction temperature instead of 440 °C. Once again graphite and stainless steel specimens were coated with a bright, smooth, adherent, coherent, and uniform coating. The coating thickness on stainless steel and graphite specimens was 15 and 13 micrometers, respectively. The coating on graphite and stainless steel specimens was free of columnar grains as shown in Figure 5. The etched cross-section of the coating showed some dark areas enriched with W₃C, indicating that the distribution of W and W₃C in this coating was considerably better than that obtained in Example 3A. The coating was found to contain a mixture of W and W₃C phases by X-ray diffraction (Table 2).

Example 3C

The CVD run described in Example 3A was repeated once again with the exceptions of using 35 minutes reaction time and 447 °C reaction temperature. All the specimens were coated with a bright, smooth, adherent, coherent and uniform coating. The coating thickness on graphite specimens was 16 micrometers. The coating was, once again, free of columnar grains. X-ray diffraction analysis revealed the presence of W and W₃C phases in the coating. The crystallite size of W and W₃C phases determined by X-
ray diffraction technique was 10.2 and 9.2 nm (102 and 92 Å), respectively, indicating the fine-grain structure of W + W3C coating.

Examples 3D to 3F

Three different CVD runs were carried out using several AM-350 stainless steel and IN-718 specimens. All the specimens were plated with 3-5 μm thick nickel using electrolytic technique. The specimens were heated to 443 °C and a gaseous mixture of 300 cm³/min WF₆ and 3,000 cm³/min of hydrogen was passed into the furnace over the specimens. Additionally, 300 cc/min of inert argon were passed over the specimens. The flow rate of DME was varied from 30 to 50 cm³/min in these runs to change the WF₆/DME ratio from 10.0 to 6. The W/C atomic ratio varied from 5 to 3 in these runs. A total pressure of 5333 Pa (40 Torr) was maintained to vary DME partial pressure from 44-73.3 Pa (0.33 to 0.55 Torr). (see Table 1). A constant deposition time of 30 minutes and a constant H₂/WF₆ ratio of 10.0 were used in these runs.

All the specimens used in these runs were coated with a bright, smooth, adherent, coherent, and uniform coating. The coating thickness on stainless steel specimens varied between 10 and 12 μm. The coating obtained in all the three runs was free of columnar grains. It had a smooth surface finish. The hardness of the coating varied between 2361 and 2470 Vickers. X-ray diffraction analysis indicated that coating consisted of a mixture of W and W₃C phases (see Table 2). The crystallite size of W phase was approximately 14 nm (140 Å) and it was unchanged with increasing flow rate of DME or decreasing WF₆/DME ratio or decreasing W/C atomic ratio or increasing DME partial pressure. However, the crystallite size of W₃C unexpectedly increased from 9.2-11.9 nm (92 to 119 Å) by increasing DME partial pressure from 44-73.3 Pa (0.33 to 0.55 Torr) or decreasing WF₆/DME ratio from 10 to 6 or decreasing W/C atomic ratio from 5 to 3.

Comparing Examples 3B and 3E, it can be seen that the addition of inert argon reduces DME partial pressure without changing coating composition. This observation indicates that the ratio of WF₆/DME or W/C atomic ratio is very critical for controlling coating composition.

Example 3G

To determine the effect of coating temperature, another CVD run was conducted using reaction conditions and specimens identical to those used in Example 3F. A lower temperature (431 °C) was used for coating. All the specimens were coated with smooth, bright, adherent, coherent and uniform coating. Coating thickness on AM-350 specimens was 8 μm. It had non-columnar grains and consisted of a mixture of W and W₃C phases. The crystallite size of W and W₃C phases was found to be similar to that observed in Example 3F (see Table 2).

This Example shows that W + W₃C coating can be deposited at lower temperature.

Example 3H

In this Example, a SiC-6 graphite specimen was coated in a CVD run. The specimen was heated to a much lower temperature 371 °C and a gaseous mixture of 350 cm³/min of WF₆, 3,500 cm³/min of hydrogen and 65 cm³/min of DME was passed into the furnace over the specimen. A total pressure of 5333 Pa (40 Torr) was used to provide a DME partial pressure of 88 Pa (0.66 Torr). The ratio of WF₆/DME and H₂/WF₆ used in this Example were 5.38 and 10.0, respectively. Additionally, the W/C atomic ratio used in this Example was 2.69.

The graphite specimen was coated with a bright, smooth, adherent, coherent, and uniform coating. Coating thickness was approximately 6 μm. It was free of columnar grains and consisted of a mixture of W and W₃C phases.

This Example clearly shows that a mixture of W and W₃C coating can be deposited at extremely low temperature (~370 °C). Additionally, it shows that high DME partial pressure or low WF₆/DME ratio or low W/C atomic ratio can be used at low temperature to yield W + W₃C coating.

Example 3I

In this Example, several specimens of AM-350 stainless steel and graphite were coated in a run. The stainless steel specimens were nickel plated prior to coating using electrolytic technique. The specimens were heated to a temperature of about 445 °C and a gaseous mixture of 30 cm³/min WF₆, 3,300 cm³/min of hydrogen and 80 cm³/min of DME was passed into the furnace over the specimens. A total pressure of
5333 Pa (40 Torr) was maintained in the run to give 88 Pa (0.66 Torr) partial pressure of DME. A W/\text{DME} ratio of 5.0, a W/C atomic ratio of 2.5 and a H\textsubscript{2}/W\text{F\textsubscript{6}} ratio of 11.0 were used during the run. The deposition was conducted for 40 minutes (see Table 1). All the specimens were coated with a bright, smooth, adherent, coherent, and uniform coating. The coating thickness on AM-350 stainless steel specimens was ~14\textmu m. The coating was free of columnar grains and consisted of a mixture of W and W\textsubscript{2}C phases.

This Example clearly shows that a mixture of W and W\textsubscript{2}C coating can be deposited using high H\textsubscript{2}/W\text{F\textsubscript{6}} ratio (~11.0). Additionally, it shows that high DME partial pressure or low W\text{F\textsubscript{6}}/DME ratio or low W/C atomic ratio can be used to yield W + W\textsubscript{2}C coating.

**EXAMPLES FOR TUNGSTEN CARBON ALLOY (W + W\textsubscript{2}C + W\textsubscript{3}C) COATING**

**Example 4A**

In this Example, several specimens of AM-350 and SS-422 stainless steel and IN-718 were coated simultaneously in a run. All the specimens were nickel plated prior to coating using electrolytic technique. The specimens were heated to a temperature of about 445°C and a gaseous mixture of 300 cm\textsuperscript{3}/min W\text{F\textsubscript{6}}, 3,000 cm\textsuperscript{3}/min of hydrogen and 55 cm\textsuperscript{3}/min of DME was passed into the furnace over the specimens. A total pressure of 5332 Pa (40 Torr) was maintained in the run to give 88 Pa (0.66 Torr) partial pressure of DME. A W/\text{DME} ratio of 5.45, a W/C atomic ratio of 2.72 and a H\textsubscript{2}/W\text{F\textsubscript{6}} ratio of 10.0 were also maintained during the run. The deposition was conducted for 20 minutes (see Table 1).

All the specimens were coated with a bright, smooth, adherent, coherent, and uniform coating. The coating thickness on AM-350 stainless steel specimens was ~8 \textmu m. The coating was free of columnar grains and consisted of coarse layered structure (see Figure 6). The etched cross-section of the coating showed uniform distribution of W, W\textsubscript{2}C and W\textsubscript{3}C. The distribution of W, W\textsubscript{2}C and W\textsubscript{3}C was considerably better than the distribution of W and W\textsubscript{2}C in the coatings described in Examples 3A and 3B. Furthermore, the coating had a smooth surface finish as shown in Figure 7. The average surface finish of uncoated specimen was 0.04 cm (16 micro-inch); whereas, the average surface finish of coated specimen was 0.013 cm (5 micro-inch). This, therefore, indicated that the coating significantly improved the surface finish. The composition of the coating determined by X-ray diffraction revealed presence of a mixture of three phases, namely W, W\textsubscript{2}C and W\textsubscript{3}C (see Table 2).

Comparing this Example to Examples 3A to 3H, it can be seen that the use of lower W\text{F\textsubscript{6}}/DME ratio or lower W/C atomic ratio or higher DME partial pressure unexpectedly results in the formation of W + W\textsubscript{3}C + W\textsubscript{2}C coating rather than W + W\textsubscript{2}C coating. Besides difference in coating composition, the microstructure of W + W\textsubscript{2}C + W\textsubscript{3}C coating shown in Figure 6 is dramatically different from the W + W\textsubscript{2}C coating shown in Figure 3. The hardness of W + W\textsubscript{2}C + W\textsubscript{3}C coating, however, is very similar to that of W + W\textsubscript{2}C coating.

Comparing this Example to Example 3H, it can be seen that reaction temperature is very important for controlling coating composition and microstructure. Example 3H resulted in the formation of W + W\textsubscript{2}C coating despite the use of lower W\text{F\textsubscript{6}}/DME ratio or lower W/C atomic ratio or higher DME partial pressure.

**Example 4B**

The CVD run described in Example 4A was repeated using a number of AM-350 specimens. The reaction conditions used were the same with the exceptions of using 443°C reaction temperature, 15 minutes reaction time and 300 cc/min of argon gas. The addition of argon gas did not alter the W\text{F\textsubscript{6}}/DME, W/C atomic and H\textsubscript{2}/W\text{F\textsubscript{6}} ratios, but reduced the DME partial pressure to 80 Pa (0.60 Torr). All the specimens were coated with a bright, smooth, adherent, coherent, and uniform coating. The coating thickness was ~14 \textmu m. The coating was free of columnar grains and had coarse layered structure. X-ray diffraction analysis of the coating indicated the presence of W, W\textsubscript{2}C and trace amounts of W\textsubscript{3}C phases.

This Example, demonstrates the importance of W\text{F\textsubscript{6}}/DME ratio or W/C atomic ratio and temperature for controlling coating composition. A small drop in temperature in this Example compared to Example 4A causes a dramatic reduction in the amount of W\textsubscript{2}C in the coating. A small decrease in DME partial pressure while maintaining W\text{F\textsubscript{6}}/DME ratio or W/C atomic ratio, however, does not cause a change in overall coating composition.
Example 4C

In this Example several AM-350, SS-422 and IN-718 specimens similar to those used in Example 4A were coated using the reaction conditions very similar to those used in Example 4B with the exceptions of using slightly higher DME flow rate and reaction time. The DME flow rate used was 60 ml/min causing W/Fe ratio to decrease to 5.0, C/Fe atomic ratio to decrease to 2.50 and DME partial pressure increase to 88 Pa (0.66 Torr). A H2/Fe ratio used during coating was 10.0. All the specimens were coated with a bright, smooth, adherent, coherent, and uniform coating. The coating was free of columnar grains and had coarse layered structure. The coating thickness was 12 μm. It had a hardness of over 2,000 Vickers. X-ray diffraction analysis of the coating revealed the presence of W, W2C and a trace amount of W2C. This Example, therefore, indicated that a decrease in WF6/DME ratio from 5.45 to 5.0 or C/Fe atomic ratio from 2.7 to 2.50 and increase in DME partial pressure from 80 to 88 Pa (0.60 to 0.68 Torr) were not effective in changing coating composition. The crystallite size of W and W2C determined by X-ray diffraction was 8 and 5.2 nm (80 and 52 Å), respectively, indicating fine-grained microstructure of the coating. The crystallite sizes of W + W2C + W2C coating was somewhat smaller than that of W + W2C coating (compare Examples 3H and Example 4C).

Comparing this Example to Example 3l, it can be seen that H2/Fe ratio is very important for controlling coating composition and microstructure. Example 3l resulted in the formation of W + W2C coating despite the use of similar WF6/DME ratio, W/C atomic ratio and DME partial pressure.

Example 4D

The CVD run described in Example 4C was repeated using similar specimens and reaction conditions with the exception of using lower reaction time (20 min.) and slightly higher DME flow rate (62 cm³/min.). Use of 62 cm³/min. DME flow rate reduced WF6/DME ratio to 4.84, reduced C/Fe atomic ratio to 2.41 and increased DME partial pressure to 90.6 Pa (0.68 Torr). It, however, did not result in any change in H2/Fe ratio. Once again, all the specimens were coated with a bright, smooth, adherent, coherent and uniform coating. The coating thickness was 5 μm. It was free of columnar grains and had coarse layered structure. X-ray diffraction analysis revealed presence of W, W2C and W2C phases in the coating. The crystallite size of W and W2C phases in the coating are summarized in Table 2.

This Example shows that at certain DME partial pressure or WF6/DME ratio or W/C atomic ratio, a small increase in DME partial pressure or decrease in WF6/DME ratio or W/C atomic ratio causes a major change in coating composition. A small increase in DME partial pressure causes the amount of W2C in the coating to increase from trace amount to minor component.

Example 4E

The CVD run described in Example 4A was repeated using same type of specimens and similar reaction conditions with the exception of using higher reaction temperature (451 °C as opposed to 445 °C). All the specimens were coated with a bright, smooth, adherent, coherent and uniform coating. The coating thickness on AM-350 specimens was 13 μm. It was free of columnar grains and had coarse layered microstructure. The coating consisted of W, W2C and W2C phases, indicating no major change in coating composition by increasing reaction temperature from 445 to 451 °C.

Example 4F

Several AM-350 stainless steel and SiC-6 graphite specimens were placed in the reactor described earlier. AM-350 stainless steel specimens were electroplated with 4-5 μm thick nickel prior to coating operation. The reactor was heated to 462 °C and a flow of 300 cm³/min of WF6, 3,000 cm³/min of hydrogen and 60 cm³/min of DME was established through the reactor for 35 minutes. A total pressure of 5333 Pa (40 Torr), was maintained during the reaction. These flow ratio and pressure resulted in a WF6/DME ratio of 5.0, a C/Fe atomic ratio of 2.50, a H2/Fe ratio of 10.0, and DME partial pressure of 94.6 Pa (0.71 Torr). All the specimens were coated with a bright, shiny, smooth, adherent and coherent coating. The coating thickness on AM-350 specimens was 15 μm. It was free of columnar grains and consisted of fine layered structure. X-ray diffraction analysis revealed that the coating consisted of a mixture of W, W2C, and W2C phases, as shown in Table 2. The crystallite size of the coating varied from 7.3 to 16.4 nm (73 to 164 Å), as shown in Table 2.
This Example, therefore, demonstrates that a mixture of W, W₂C, and W₃C coating can be formed by using WF₆/DMF ratio of 5.0 or W/C atomic ratio of 2.50, H₂/WF₆ ratio of 10.0, DME partial pressure of 94.6 Pa (0.71 Torr), and a temperature of 462 °C. It also demonstrates that coating microstructure changes to fine layered structure by increasing the reaction temperature.

Example 4G

An experiment similar to that described in Example 4F was carried out again. This time only SiC-6 graphite specimens were used. The flow rate of DME was increased from 60 to 70 cm³/min to provide a WF₆/DME ratio of 4.29 or W/C atomic ratio of 2.14 and a DME partial pressure of 110.6 Pa (0.83 Torr). A H₂/WF₆ ratio of 10.0 was maintained during the run. A reaction time of 40 min was used. Other conditions were kept the same. Once again, all the specimens were coated with a bright, smooth, adherent and coherent coating of 13 μm thickness. The coating was free of columnar grains, and consisted of fine layered structure. X-ray diffraction analysis of the coating revealed presence of W, W₂C and trace amount of W₃C phases (see Table 2). The crystallite size of the coating varied from 12 to 15 nm (120 to 150 Å), as shown in Table 2.

This Example clearly shows that a coating consisting of a mixture of W, W₂C and W₃C can be formed by using 462 °C temperature, 4.29 WF₆/DME ratio or W/C atomic ratio of 2.14, 10.0 H₂/WF₆ ratio and 110.6 Pa (0.83 Torr) DME partial pressure. It also indicates that increasing DME partial pressure or decreasing WF₆/DME ratio of W/C atomic ratio is responsible for reducing the amount of W₃C in the coating.

Example 4H

A CVD experiment using SiC-6 graphite specimens was carried out in a reactor similar to that described earlier. This time flow rate of 300 cm³/min of WF₆, 3,000 cm³/min of hydrogen and a very low flow 40 cm³/min of DME was used. A reaction time of 40 min and a total pressure of 5333 Pa (40 Torr) were used for the coating experiment. These flow rates and pressure provided WF₆/DME ratio of 7.5, W/C atomic ratio of 3.75, H₂/WF₆ ratio of 10.0 and DME partial pressure of 64 Pa (0.48 Torr). A reaction temperature of 467 °C was used. All the specimens were coated with a bright, smooth, adherent and coherent coating of ~22 μm thickness. The coating was free of columnar grains and consisted of coarse layered structure. X-ray diffraction analysis revealed that the coating consisted of a mixture of W, W₂C and trace amount of W₃C phases.

Comparing Examples 3A, 3B and 3C to Example 4H, it can be seen that increasing reaction temperature from ~447 °C to 467 °C results in an unexpected change in coating composition. This Example, therefore, shows the importance of reaction temperature in controlling coating composition.

Example 4I

CVD experiment described in Example 4H was repeated with 35 cc/min. of DME rather than 40 cm³/min. Other conditions were kept constant. The reduction in DME flow rate caused WF₆/DME ratio to increase to 8.57, W/C atomic ratio increase to 4.23 and DME partial pressure to drop to 56 Pa (0.42 Torr). A H₂/WF₆ ratio of 10.0, however, was maintained during the run. Once again, all the specimens were coated with a bright, smooth, adherent and coherent coating of ~21 μm thickness. The coating was free of columnar grains and consisted of coarse layered structure. X-ray diffraction analysis revealed that the coating consisted of a mixture of W, W₂C and trace amount of W₃C phases. This Example showed that a mixture of W, W₂C and W₃C can be formed at 467 °C, 8.57 WF₆/DME ratio, W/C atomic ratio of 4.23, 10.0 H₂/WF₆ ratio and 56 Pa (0.42 Torr) DME partial pressure.

Example 4J

CVD experiment described in Example 4I was repeated with using 6665 Pa (50 Torr) total pressure and 474 °C reaction temperature. The change in total pressure caused DME partial pressure to increase from 56 to 69.3 Pa (0.42 to 0.52 Torr), but it did not affect the WF₆/DME, W/C atomic and H₂/WF₆ ratios. All the specimens were coated with a bright, smooth, adherent, and coherent coating of ~22 μm thickness. The coating was free of columnar grains, and consisted of coarse layered structure. X-ray diffraction analysis revealed that the coating consisted of a mixture of W, W₂C and W₃C phases. This Example shows that increasing both temperature and DME partial pressure cause the amount of W₃C in the coating to increase (compare Examples 4I and 4J). This finding is unexpected.
Example 4K

CVD experiment described in Example 4J was repeated with using 13330 Pa (100 Torr) total pressure, 24 cm³/min DME, 400 cm³/min WF₆, and 4,000 cm³/min hydrogen flow rates, 477°C reaction temperature, and 15 min. reaction time. These flow rates and pressure caused WF₆/DME ratio, W/C atomic ratio and DME partial pressure to increase to 16.7, 8.35 and 72 Pa (0.54 Torr), respectively. A constant H₂/WF₆ ratio of 10.0, however, was used during the run. All the specimens were coated with a bright, smooth, adherent, and coherent coating of 20 μm thickness. The coating was free of columnar grains, and consisted of coarse layered structure. X-ray diffraction analysis revealed that the coating consisted of a mixture of W, W₂C and a trace amount of W₂C phases.

This Example, therefore, indicates that a mixture of W, W₂C and W₂C can be formed by using 477°C temperature, 16.7 WF₆/DME ratio, 8.35 W/C atomic ratio, 10.0 H₂/WF₆ ratio and 72 Pa (0.54 Torr) DME partial pressure.

Example 4L

In this Example, several AM-350 and IN-718 specimens similar to those used in Example 4A were coated. The specimens were heated to a temperature of about 445°C and a gaseous mixture of 220 cm³/min WF₆, 2,400 cm³/min of hydrogen, 3,000 cm³/min of argon and 60 cm³/min of DME was passed into the furnace over the specimens. A total pressure of 5333 Pa (40 Torr) was maintained in the run to give 56 Pa (0.42 Torr) partial pressure of DME. A WF₆/DME ratio of 3.33, W/C atomic ratio of 1.67, and a H₂/WF₆ ratio of 12.0 were also maintained during the run. The deposition was conducted for 90 minutes (see Table 1).

All the specimens were coated with a bright, smooth, adherent, coherent, and uniform coating. The coating thickness was AM-350 stainless steel specimens was ~13μm. The coating was fine of columnar grains and consisted of course layered structure. X-ray diffraction analysis of the coating indicated the presence of W, W₂C and W₂C phases (see Table 2).

This example, therefore, indicates that a mixture of W, W₂C and W₂C can be formed using 445°C temperature, 3.33 WF₆/DME ratio, 1.67 W/C atomic ratio, 12.0 H₂/WF₆ ratio, and 56 Pa (0.42 Torr) DME partial pressure. It also indicates that a low WF₆/DME ratio or W/C atomic ratio can be used to produce W + W₂C coating provided a H₂/WF₆ ratio of 12.0 is used. This example also indicates the importance of H₂/WF₆ ratio for controlling coating composition.

Examples 4M and 4N

In these examples, several AM-350 and IN-718 specimens similar to those used in Example 4A were coated. The specimens were heated to a temperature of about 445°C and a gaseous mixture of 200 cm³/min WF₆, 2,400 cm³/min of hydrogen, 6,000 cm³/min argon and 60 cm³/min of DME was passed into the furnace over the specimens in both runs. A total pressure of 5332 Pa (40 Torr) was maintained in the run to give 37.3 Pa (0.28 Torr) partial pressure of DME. A WF₆/DME ratio of 3.33, W/C atomic ratio of 1.67 and a H₂/WF₆ ratio of 12.0 were also maintained during the two runs. The deposition was conducted for 90 and 80 minutes, respectively (see Table 1).

All the specimens were coated with a right, smooth, adherent, coherent, and uniform coating. The coating thickness on AM-350 stainless steel was ~12μm. The coating was free of columnar grains and consisted of coarse layered structure. X-ray diffraction analysis of the coating indicated the presence of W, W₂C and W₂C phases (see Table 2).

These examples show that a mixture of W, W₂C and W₂C can be formed using extremely low DME partial pressure provided WF₆/DME ratio or W/C atomic ratio is maintained below certain level.

Comparing examples L and M it is clearly evident that the addition of diluent argon simply lowers the partial pressure of DME. It does not effect WF₆/DME, W/C atomic and H₂/WF₆ ratios. Therefore, it does not cause any changes in coating composition.

EXAMPLES FOR TUNGSTEN-CARBON ALLOY (W + W₂C) COATING

Example 5A

Five 0.24 cm x 2.54 cm x 5.08 cm (0.095 inch x 1 inch x 2 inch) SiC-6 graphite specimens were placed in an inductively heated graphite furnace inside a gas-tight quartz envelope. The specimens were heated to
a temperature of 477 °C and a gaseous mixture of 400 cm³/min of WF₆, 4,000 cm³/min of hydrogen, and 85 cm³/min of DME was passed into the furnace over the specimens. The total pressure within the system was maintained at 1.33 x 10⁵ Pa (100 Torr) to provide a DME partial pressure of 194.6 Pa (1.46 Torr). The ratios of WF₆/DME, W/C atomic and H₂/WF₆ used were 6.15, 3.08 and 10.0, respectively. The deposition was conducted for 15 minutes; thereafter, the flow of the reactive gases was stopped and the specimens were cooled.

The specimens were found to be coated with a bright, smooth, adherent, coherent, and uniform coating of 25 micrometers thick on each side (see Table 1). The coating was free of columnar grains. It consisted of extremely fine grains. Additionally, it had a well-defined layered microstructure with layers 1-2 µm thick.

The coating had a hardness of 2512 Vickers. The composition of the coating was determined by X-ray diffraction. It was comprised of a mixture of W and WₓC phases, as shown in Table 2.

Comparing this Example to Example 4K, it can be seen that increasing DME partial pressure and decreasing WF₆/DME ratio or W/C atomic ratio simultaneously causes an unexpected change in coating composition. Additionally, it results in higher coating hardness.

Example 5B

Several AM-350 and SiC-6 graphite specimens were coated in a reactor similar to that described in Example 5A. A reaction temperature of 463 °C, total pressure of 5333 Pa (40 Torr) and flow rate of 300 cm³/min WF₆, 3,000 cm³/min hydrogen and 85 cm³/min of DME were used for the reaction. Reaction time used was 50 min. These conditions provided WF₆/DME ratio, W/C atomic ratio and DME partial pressure of 3.53, 1.77 and 133.3 Pa (1.00 Torr), respectively. These conditions also provided H₂/WF₆ ratio of 10.0. All the specimens were coated with a bright, smooth, adherent, coherent, and uniform coating of 25 µm thick (AM-350) on each side (see Table 1). The coating was free of columnar grains. Additionally, it had a well-defined fine layered microstructure with layers less than 1 µm apart. The coating had a hardness of 2758 Vickers. The coating was found to contain a mixture of W and WₓC phases. The crystallite size of the coating was less than 5 nm (50 Å).

This Example, therefore, shows that a mixture of W and WₓC can be formed by using 463 °C temperature, 3.53 WF₆/DME ratio, 1.77 W/C atomic ratio, 10.0 H₂/WF₆ ratio and 1.33 x 10⁵ Pa (1.00 Torr) DME partial pressure. Additionally, it indicates that the crystallite size of the coating is considerably smaller than that noted in Examples 3 and 4. Furthermore, it indicates that the hardness of the coating is considerably higher than that noted in Examples 3 and 4.

Example 5C

CVD experiment described in Example 5B was repeated with the exception of using 443 °C temperature and 35 minutes reaction time. All the specimens were, once again, coated with bright, smooth, adherent, coherent, and uniform coating of 20 µm thick on each side (see Table 1). The coating was free of columnar grains. It consisted of a well-defined layered structure, as shown in Figure 8. The etched cross-section of the coating showed very uniform distribution of W and WₓC. The coating had a smooth surface finish as shown in Figure 9. The average surface finish of uncoated AM-350 stainless steel specimen was 0.14 cm (54 micro-inch); whereas, the coated specimen had an average surface finish of 0.08 cm (33 micro-inch). This, therefore, indicated that W + WₓC coating considerably improved the surface finish of the specimen. X-ray diffraction analysis of the coating revealed the presence of W and WₓC phases in the coating. The crystallite size was less than 5 nm (50 Å) (see Table 2).

This Example shows that a mixture of W and WₓC can be formed at lower temperature (443 °C) as well.

Examples 5D to 5L

A number of CVD experiments were conducted to coat AM-350, AM-355 and SS-422 stainless steel, SiC-6 graphite and IN-718 specimens simultaneously in a run. Reaction temperature was varied in a very narrow range; it was varied from 440 to 445 °C (see Table 1). Total pressure was kept constant at 5332 Pa (40 Torr) in all these runs. The flow rates of WF₆ and hydrogen were also kept the same in these runs. Flow rates of DME was varied from 70 to 100 cm³/min. Additionally, diluent argon gas was used in some experiments and not used in others. The WF₆/DME ratio was varied from 3.00 to 4.29, the W/C atomic ratio varied from 1.5 to 2.65, and the partial pressure of DME was varied from 101.3 to 144 Pa (0.76 to 1.08 Torr). However, the ratio of H₂/WF₆ was maintained at 10.0 in all the experiments. Reaction time was also varied in these experiments, as shown in Table 1.
All these experiments yielded bright, smooth, adherent, coherent, and uniform coating of varying thicknesses (see Table 1). The coating obtained in all these experiments was free of columnar grains. It consisted of well-defined fine layered structure. The coating obtained in these experiments was extremely hard, as shown in Table 1. Additionally, it consisted of mixture of W and W_2C phases (see Table 2). The crystallite size of the coating was less than 5 nm (50 Å) (see Table 2).

These Examples show wide variations in process conditions that can be used to produce W + W_2C coating.

Examples 5M and 5N

Two CVD experiments were conducted to coat AM-350, AM-355 and SS-422 stainless steel, SiC-6 graphite and IN-718 specimens simultaneously in a run. Reaction conditions used in these experiments were the same with the exception of using two different flow rate of DME (see Table 1). The partial pressure of DME used in these runs was 101.3 and 129.3 Pa (0.76 and 0.97 Torr), WF_6/DME ratio used was 3.33 and 4.29, and W/C atomic ratio used was 1.67 and 2.15. The ratio of H_2/WF_6 used in these experiments was 10.0. All the specimens were coated with bright, smooth, adherent, coherent, and uniform coating (see Table 1 for coating thickness). The coating was free of columnar grains. It consisted of fine layered microstructure. Coating was extremely hard, as shown in Table 1. It consisted of a mixture of W and W_2C phases (see Table 2). The crystallite size of the coating with higher DME partial pressure or lower WF_6/DME ratio or lower W/C atomic ratio was similar to the one obtained with lower DME partial pressure or higher WF_6/DME ratio or higher W/C atomic ratio.

Example 5O and 5P

These Examples were repeats of Examples 5M and 5N with the exception of using 454 °C reaction temperature. Once again, all the specimens were coated with bright, smooth, adherent, coherent, and uniform coating (see Table 1). The coating was free of columnar grains. It consisted of fine layered microstructure. The coating was extremely hard, as shown in Table 1. It comprised of W and W_2C phases with crystallite size less than 5 nm (50 Å).

Examples 5Q to 5U

A number of CVD experiments were conducted to coat AM-350, AM-355 and SS-422 stainless steel and IN-718 specimens simultaneously in a run. Reaction temperature in these runs was varied from 421 to 445 °C. Total pressure, flow rates of WF_6, hydrogen and DME were kept constant in these runs (see Table 1). A diluent argon gas was used in all these runs, and its flow rate was varied from 1,500 to 1,800 cm³/min. The flow rate of diluent was considerably higher than used before. The partial pressure of DME was varied from 92 to 98.6 Pa (0.69 to 0.74 Torr); however, the WF_6/DME, W/C atomic and H_2/WF_6 ratios were kept constant in these runs. Reaction time was also varied in these experiments.

All the specimens used in these runs were coated with bright, smooth, adherent, coherent, and uniform coating (see Table 1 for coating thickness). The coating was free of columnar grains. It consisted of fine layered microstructure. The hardness of coating was around 2,400 Vickers, which was considerably lower than that observed at very low argon or no argon flow rates. The coating consisted of W and W_2C phases, and the crystallite size of the coating was less than 5 nm (50 Å) (see Table 2).

These Examples clearly show that a diluent can be used during coating reaction without affecting coating composition and crystallite size. However, the diluent is found to affect coating hardness. The change in coating hardness probably is related to change in coating rate.

Comparing Examples 5T and U to Examples 4L, M and N it can be seen that the ratio of H_2/WF_6 is very important for controlling the coating composition. It has already been shown in Examples 5P to 5U that simply increasing diluent flow rate does not cause any changes in overall coating composition provided WF_6/DME, W/C atomic and H_2/WF_6 ratios are kept constant. Examples 4L and 4N, on the other hand, show that increasing H_2/WF_6 ratio from 10.0 as used in Examples 5P to 5U to 12.0 changes the coating composition from W + W_2C to W + W_2C + W_5C. These examples, therefore, demonstrate the importance of H_2/WF_6 ratio.
Example 5V

Several AM-350 and IN-718 specimens were coated in a reactor similar to that described in Example 5A. A reaction temperature of 445 °C, total pressure of 5333 Pa (40 Torr) and flow rate of 200 cm³/min. WFG, 2,000 cm³/min. hydrogen, 3,500 cc/min. argon and 60 cm³/min. of DME were used for the reaction. Reaction time used was 90 min. These conditions provided WFG/DME ratio of 3.33, W/C atomic ratio of 1.67, H₂/WFG ratio of 10.0 and DME partial pressure of 56 Pa (0.42 Torr). All the specimens were coated with a bright, smooth, adherent, coherent, and uniform coating of ~9μm thick (AM-350) on each side (see Table 1). The coating was fine of columnar grains. Additionally, it had a well defined five layered microstructure with layers less than 1μm apart. The coating had a hardness of 2035 Vickers. The coating was found to contain a mixture of W and W₂C phases (see Table 3). The crystallite size of the coating was less than 5 nm (50 Å).

This example, therefore, shows that low flow ratios of WFG, hydrogen and DME can be used to produce W and W₂C coatings provided WFG/DME, W/C atomic and H₂/WFG ratios are maintained.

Examples 5W and 5X

Several AM-350 and IN-718 specimens were once again coated in a reactor using two different runs using 445 °C temperature, 5333 Pa (40 Torr) total pressure and flow rate of 100 cm³/min. WFG, 1,000 cm³/min. hydrogen and 30 cm³/min. DME. Additionally, 5,000 cm³/min. of argon was used in Example W; whereas, only 4,000 cm³/min. of argon was used in Example X. Reaction time used in these runs was 150 and 180 minutes, respectively. These conditions provided WFG/DME, W/C atomic and H₂/WFG ratios of 3.33, 1.67 and 10.0, respectively. All the specimens were coated with a bright, smooth, adherent, coherent and uniform coating of ~9μm thick on each side (see Table 1). The coating was free of columnar grains and consisted of a mixture of W and W₂C phases.

These examples, once again, show that low flow rates of WFG, hydrogen and DME can be used to produce W and W₂C coatings provided WFG/DME, W/C atomic and H₂/WFG ratios are maintained.

Example 5Y

In this example several AM-350 and IN-718 specimens were coated in a run. A reaction temperature of 445 °C, total pressure of 5333 Pa (40 Torr) and flow rate of 200 cm³/min. WFG, 1,600 cm³/min. of hydrogen, 4,000 cm³/min. of argon and 60 cm³/min. of DME were used for the reaction. Reaction time used was 100 min. These conditions provided WFG/DME ratio, W/C atomic ratio and DME partial pressure of 3.33, 1.67 and 54.7 Pa (0.41 Torr), respectively. The ratio of H₂/WFG used was 8.0, which was greater than the stoichiometric ratio required for complete conversion of WFG to HF gas. All the specimens were coated with a bright, smooth, adherent, coherent, and uniform coating of ~9 μm thick on each side. The coating was free of columnar grains and consisted of a mixture of W and W₂C phases.

This example, therefore, shows that a mixture of W and W₂C can be produced provided a certain ratio of WFG/DME or W/C atomic ratio and more than stoichiometric amount of hydrogen required for complete conversion of WFG to HF are used.

Example 5Z

In this example, several AM-350 and IN-718 specimens were coated in a run. A reaction temperature of 445 °C, total pressure of 5333 Pa (40 Torr) and flow rate of 200 cm³/min WFG, 1,200 cm³/min. hydrogen, 4,500 cm³/min. argon and 60 cm³/min. DME were used for the reaction. The reaction time used was 130 min. These conditions provided WFG/DME ratio, W/C atomic ratio and DME partial pressure of 3.33, 1.67 and 53.3 Pa (0.40 Torr), respectively. The ratio of H₂/WFG used was 6.0, which was greater than the stoichiometric ratio required for complete conversion of WFG and HF gas. All the specimens were coated with a bright, smooth, adherent, coherent, and uniform coating of ~10μm thick on each side. The coating was free of columnar grains and consisted of a mixture of W and W₂C phases.

This example, once again, shows that a mixture of W and W₂C can be produced provided a certain ratio of WFG/DME or W/C atomic ratio and more than stoichiometric amount of hydrogen required for complete conversion of WFG to HF are used.
Example 6

In this Example, two specimens of cemented carbide (94% tungsten carbide and 6% cobalt) were coated in a run. The specimens were not nickel plated prior to coating experiment. The specimens were heated to a temperature of about 445 °C and a gaseous mixture of 300 cm³/min. WF₆, 3,000 cm³/min. of hydrogen and 55 cm³/min. of DME was passed into the furnace over the specimens. A total pressure of 5333 Pa (40 Torr) was maintained in the run to give 88 Pa (0.66 Torr) partial pressure of DME. A WF₆/DME ratio of 5.45, W/C atomic ratio of 2.73, and H₂/WF₆ ratio of 10.0 were maintained during the run. The deposition was conducted for 20 minutes.

The specimens were coated with a bright, smooth, adherent, coherent, and uniform coating. The coating thickness was ~ 8μm. The coating was free of columnar grains and consisted of layered structure. The etched cross-section of the coating showed uniform distribution of W, W₂C and W₃C. The coating had a smooth surface finish.

This example therefore shows that the tungsten/carbon alloy coatings of the present invention can be deposited on cemented carbide. Additionally, it shows that there is no need to provide a nickel or copper inter-layer to protect the cemented carbide while depositing tungsten/carbon alloys.

Example 7

In this example, two specimens of titanium alloy (Ti/6Al/4V) were coated in a run. Both the specimens were plated with 4-5 μm thick nickel using electroless nickel technique. The specimens were heated to a temperature of about 445 °C and a gaseous mixture of 300 cm³/min. WF₆, 3,000 cm³/min. of hydrogen and 55 cm³/min. of DME was passed into the furnace over the specimens. A total pressure of 5333 Pa (40 Torr) was maintained in the run to give 88 Pa (0.66 Torr) partial pressure of DME. A WF₆/DME ratio of 5.45 or W/C atomic ratio of 2.73 was also maintained during the run. A H₂/WF₆ ratio of 10.0 was also maintained during the run. The deposition was conducted for 20 minutes.

The specimens were coated with a bright, smooth, adherent, coherent, and uniform coating. The coating thickness was ~ 8μm. The coating was free of columnar grains and consisted of layered structure. X-ray diffraction analysis revealed the presence of W, W₂C and W₃C in the coating.

This example clearly shows that titanium alloys can be coated with tungsten/carbon alloys described in the present invention. However, a protective nickel layer is required before coating titanium alloys with tungsten/carbon alloys.

Example 8

In this example, several specimens of 2219 aluminum were coated in a CVD run. All the specimens were plated with 4-5 μm thick nickel using electroless technique. The specimens were heated to a temperature of about 371 °C and a gaseous mixture of 350 cm³/min. WF₆, 3,500 cm³/min. of hydrogen and 65 cm³/min. of DME was passed into the furnace over the specimens for 20 minutes. A total pressure 5333 Pa (40 Torr) was used to provide a DME partial pressure of 88 Pa (0.66 Torr). The ratio of WF₆/DME used was 5.38. Additionally, the H₂/WF₆ and W/C atomic ratios used were 10.0 and 2.69, respectively.

All the specimens were coated with a bright, smooth, adherent, coherent and uniform coating. Coating thickness was approximately 5 μm. It was free of columnar grains and consisted of a mixture of W and W₂C phases.

This example clearly shows that tungsten/carbon alloy can be deposited on aluminum. However, a protective nickel layer is required before coating aluminum with tungsten/carbon alloys.

Example 9

In this example, two specimens of alumina (Al₂O₃) were coated in a run. The specimens were not nickel plated prior to coating experiment. The specimens were heated to a temperature of about 443 °C and a gaseous mixture of 300 cm³/min. of WF₆, 3,000 cm³/min. of hydrogen, 70 cm³/min. of DME and 300 cm³/min. of argon was passed into the furnace over the specimens. A total pressure of 5333 Pa (40 Torr) was maintained in the run to give 101.3 Pa (0.76 Torr) partial pressure of DME. A WF₆/DME ratio of 4.29 and W/C atomic ratio of 2.15 were also maintained during the run. Additionally, a H₂/WF₆ ratio of 10.0 was maintained during the run. The deposition was conducted for 40 minutes.

The specimens were coated with a bright smooth, adherent, coherent and uniform coating of ~ 12μm thickness. The coating was free of columnar grains and consisted of layered structure. X-ray diffraction
revealed the pressure of W, W₂C and W₃C in the coating. The coating had a smooth surface finish.

This example shows that tungsten/carbon alloy coatings of the present invention can be deposited on ceramic substrates such as alumina. Additionally, it shows that there is no need to provide a nickel or copper interlayer to protect the ceramic substrates while depositing tungsten/carbon alloys.

Example 10

In this example, two 15.24 x .635 cm (six-inch long and 1/4" diameter) molybdenum rods were coated in a run. The molybdenum rods were not nickel plated prior to coating experiment. The rods were heated to a temperature of about 445°C and a gaseous mixture of 300 cm³/min. WF₆, 3,000 hydrogen and 40 cm³/min. of DME was passed into the furnace over the specimens for 90 minutes. A total pressure of 5332 Pa (40 Torr) was used to provide a DME partial pressure of 64 Pa (0.48 Torr). The ratio of WF₆/DME used was 7.5. Additionally, the H₂/WF₆ and W/C atomic ratio used were 10.0 and 3.75, respectively.

Both rods were coated with a bright smooth, adherent, coherent and uniform coating of ~13μm thickness. It was free of columnar grains and consisted of a mixture of W and W₂C phases.

This example shows that tungsten/carbon alloys of the present invention run be deposited on molybdenum without a protective interlayer.

Example 11

The experiment described in Example 10 was repeated with the exception of using higher (55 cm³/min) DME flow rate. This high DME flow rate provided a DME partial pressure of 88 Pa (0.66 Torr). The WF₆/DME and W/C atomic ratios used were 5.5 and 2.75, respectively. The ratio of H₂/WF₆ used was 10.0.

Both rods were, once again, coated with a bright, smooth, adherent, coherent and uniform coating of ~11μm thickness. It was free of columnar grains and consisted of mixture of W, W₂C and W₃C phases.

This example clearly shows that tungsten/carbon alloys of the present invention can be deposited on molybdenum without a protective interlayer.

Example 12

In this example, a two step coating process was used. Several AM-350, Ti/6Al/4V and IN-718 specimens were placed in an inductively heated furnace. All the specimens were plated with 3-4μm thick nickel using either electrolytic or electrolyless technique prior to CVD experiment. The specimens were heated to a temperature of about 442°C and a gaseous mixture of 300 cm³/min. WF₆ and 3,000 cm³/min. of hydrogen was passed into the furnace over the specimens for five minutes to coat them with tungsten.

After coating the specimens with tungsten for five minutes, a gaseous mixture of 300 cm³/min. WF₆, 3,000 cm³/min. of hydrogen and 40 cm³/min. of DME was passed into the furnace for 55 minutes to provide tungsten/carbon alloy coating. A total pressure of 5333 Pa (40 Torr) was maintained during the run to provide a DME partial pressure of 64 Pa (0.48 Torr), a WF₆/DME ratio of 7.5, and a W/C atomic ratio of 3.75, respectively. Additionally, a H₂/WF₆ ratio of 10.0 was used during the coating steps.

All the specimens were coated with 2-3 μm thick tungsten followed by 27-28 μm thick tungsten/carbon alloy. The coating was bright, smooth, adherent, coherent and uniform. The tungsten interlayer had a well defined columnar structure; whereas, tungsten/carbon alloy had non-columnar structure. It consisted of a mixture of W and W₂C phases.

This example clearly shows that the tungsten/carbon alloys can be deposited on various substrates with a tungsten interlayer.

Example 13

The erosion performance of some of the coated specimens was determined using a miniature sandblast unit. Crushed glass with average particle size of 50 micrometers was directed at the coated and uncoated specimens at an angle of 90° for 10 minutes using the test procedure summarized in Table 3. The erosion performance of uncoated and coated specimens was determined based upon weight loss as well as calculated volume loss in 10 minutes.

AM-350 stainless steel specimens uncoated and coated in Examples 3C, 4F and 5C with W + W₂C, W + W₂C + W₃C and W + W₂C coatings, respectively, were tested for erosion performance. The test results summarized in Table 4 indicated that coated specimens outperformed uncoated specimen both on weight loss basis as well as volume loss basis. Surprisingly, the erosion performance of W + W₂C + W₃C
coating was far superior to that of W + W$_2$C coating (see Table 4). Additionally, erosion performance of W + W$_2$C coating was considerably better than that of W + W$_2$C + W$_5$C and W + W$_5$C coatings.

This Example, therefore, shows that coatings described in this application provide good erosion and wear protection. Additionally, the degree of erosion and wear protection required can be manipulated by altering the coating composition.

**Example 14**

The wear performance of W + W$_2$C coating was determined using a block-on-ring test. The test machine was made by Falex Corporation, Aurora, Illinois. The wear performance of uncoated 4620 steel rings was determined against coated and uncoated 440C steel blocks. The test was conducted in a mineral oil having a viscosity of 62.5 centipoise. The oil contained 3.0 μm alumina particles in a concentration of 2 g/litre. The block-on-ring test was performed using a load of 113.4 kg (250 lb.) and 90° oscillating motion at 60 min$^{-1}$ (rpm) for 20,000 cycles. Wear scar width and weight loss were measured to determine and compare the wear performance of coated and uncoated specimens.

The test results summarized in Table 5 indicated that the coated block outperformed the uncoated block both on the basis of wear scar on - the ring and weight loss by the ring.

This example, therefore, shows that tungsten/carbon alloy coatings described in the present invention provide good wear protection.

**Example 15**

The wear performance of W + W$_2$C coating was once again determined using a pin-on-disc test. The test machine was made by Falex Corporation. The wear performance of uncoated and coated 440C steel pins was determined against uncoated SiC disc. The test was conducted in a mineral oil having a viscosity of 62.5 centipoise. It contained 3.0 μm alumina in a concentration of 2 g/litre. The pin-on-disc test was conducted using a load of 1.8 kg (4 lbs) and continuous motion at 150 min$^{-1}$ (rpm). The wear performance of the coated and the uncoated 440C steel pins was compared based upon the pin wear rate.

The test results summarized in Table 6 indicated that the coated 440C steel pin outperformed the uncoated pin; the pin wear rate on the coated specimen was ~ 18.5 times lower than the uncoated specimen despite running it more than two times longer distance.

This example shows that tungsten/carbon alloy coatings discussed in this application provide good wear protection.

**Example 16**

Several Am-350, SS-422 and IN-718 specimens are coated in an inductively heated graphite reactor similar to that described in earlier examples. A reaction temperature of 445°C, a total pressure of 5332 Pa (40 Torr) and flow rate of 300 cc/min. WF$_6$, 3,000 cm$^3$/min. hydrogen and 20 cm$^3$/min. of diethyl ether (DEE) are used for the reaction and at a reaction time of 50 minutes. These conditions provide WF$_6$/DEE ratio, W/C atomic ratio and DEE partial pressure of 15.0, 3.75, and 32 Pa (0.24 Torr), respectively. A H$_2$/WF$_6$ ratio of 10.0 is maintained during the run. Based on the previous examples set forth above, all of the specimens are expected to be coated with a bright, smooth, adherent, coherent, and uniform coating of ~20 μm thick on each side. The coating is expected to be free of columnar grains and a mixture of W and W$_2$C phases.

**Example 17**

CVD experiment described in Example 16 is repeated with using 40 cm$^3$/min. DEE instead of 20 cm$^3$/min. The increase in DEE flow rate causes a decrease in WF$_6$/DEE ratio to 7.5, a decrease in W/C atomic ratio to 1.88, and an increase in DEE partial pressure to 64 Pa (0.48 Torr). All the other reaction conditions are maintained the same as described in Example 16. All the specimens are expected to be coated with a bright, smooth, adherent, coherent, and uniform coating of ~15 μm thick on each side. The coating is expected to be free of columnar grains and a mixture of W and W$_2$C phases.
Several AM-350, SS-422 and In-718 specimens are coated in an inductively heated graphite reactor similar to that described in earlier examples. A reaction temperature of 445 °C, total pressure of 5333 Pa (40 Torr) and flow rate of 300 cm³/min. WF₆, 3,000 cm³/min. hydrogen and 40 cm³/min. of ethanol are used for the reaction. Reaction time used is 50 min. These conditions provide WF₆/ethanol ratio, W/C atomic ratio and ethanol partial pressure of 7.5, 3.75 and 64 Pa (0.48 Torr), respectively. A H₂/WF₆ ratio of 10.0 is also used during the reaction. All the specimens are expected to be coated with a bright, smooth, adherent, coherent, and uniform coating of ~20 μm thick on each side. The coating is expected to be free of columnar grains and a mixture of W and W₂C phases.

Example 19

CVD experiment described in Example 18 is repeated with using 80 cm³/min. ethanol instead of 40 cm³/min. The increase in ethanol flow rate causes a decrease in WF₆/ethanol ratio to 3.75, a decrease in W/C atomic ratio to 1.88, and an increase in ethanol partial pressure to 126.6 Pa (0.95 Torr). All the other reaction conditions are maintained the same as described in Example 3. All the specimens are expected to be coated with a bright, smooth, adherent, coherent, and uniform coating of ~15 μm thick on each side. The coating is expected to be free of columnar grains and a mixture of W and W₂C phases.

Example 20

CVD experiment described in Example 3 is repeated again with using 80 cm³/min. methanol instead of 40 cm³/min. of ethanol. This flow rate of methanol results in WF₆/methanol ratio, W/C atomic ratio, and methanol partial pressure of 3.75, 3.75, and 126.6 Pa (0.95 Torr), respectively. All the other reaction conditions are maintained the same as described in Example 18. All the specimens are expected to be coated with a bright, smooth, adherent, coherent, and uniform coating of ~20 μm thick on each side. The coating is expected to be free of columnar grains and a mixture of W and W₂C phases.

EXPERIMENTAL

X-Ray Diffraction (XRD) Instrumental Apparatus and Experimental Procedures

Diffraction experiments were performed using a manually-controlled Siemens D500 and, in a few cases, a Philips APD 3720. For most scans on the Siemens and all scans on the Philips, graphite-monocho-
romatized CuKα radiation (\(\lambda = 154.178\) pm (1.54178Å)) was employed; for some scans on the Siemens, vanadium-filtered CrKα radiation (\(\lambda = 229.092\) pm (2.29092Å)) was used. The Siemens had a \(1^\circ\) fixed
divergence slit, \(1^\circ\) scatter slits, a soller slit in the diffracted beam, a 0.15° detector slit, and, for CuKα
diffraction, a 0.15° slit in the diffracted beam monochromator. The Philips had a variable divergence slit
which kept the sample illumination length fixed at 13.2mm. Both instruments had scintillation x-ray
detectors. Data output for the Siemens was by strip-chart recording; that for the Philips was in the form of
digitized diffraction traces which were stored in files in a dedicated Micro PDP 11-23 computer.
The volume of sample illuminated by x-rays varied with the type of diffractometer and radiation
employed. The Siemens illumination area decreased as the diffraction angle (2θ) increased, while the
Philips illumination area was constant and independent of 2θ. The penetration depth is a function of x-ray
wavelength, the linear absorption coefficient of the sample, and diffraction angle. A rough calculation
showed that 99% of CuKα diffracted intensity for a reflection whose d-spacing was 225 pm (2.25Å)(2θ
\(-40^\circ\)) came from the top ~2.5μm of these tungsten-rich materials. The corresponding penetration depth for
CrKα radiation was ~1.3μm. The region between 1.3μm and 2.5μm, which effectively could not be probed
by CrKα x-rays, accounted for ~10% of the total CuKα diffracted intensity.

Diffraction scans were made for purpose of phase identification and, in some cases, for measuring
crystallite size. Survey scans over wide angular regions (usually, 5°-90° for CuKα and 15°-115° for CrKα)
at rapid scan rates (5°/min. or 2°/min.) were initially obtained. If there was some doubt about the presence
of a weakly-diffracting phase, scans were repeated at a slower (1°/min.) scan rate. d-spacings were
calculated employing the Bragg equation:

\[ \lambda = 2d \sin \theta \]  (1)
Relative intensities were taken directly from the strip-chart recordings (Siemens) or plotted diffraction traces (Philips).

Phases were identified manually by comparing observed d-spacings and relative intensities with those found in Powder Diffraction File (PDF) cards 2-1134 (W₂C), 2-1138 (W₃C)* and 4-806 (W). Due to preferred crystallite orientation, more attention was paid to the positions of lines than to their intensities.

Certain isolated peaks in the scans were rescanned slowly (1/2’/min. or 1’/min.) for the purpose of estimating crystallite size. The crystallite size is given by the Scherrer equation:

\[ \text{Crystallite Size} = \frac{c\lambda}{\beta \cos \theta}, \]

where \( c \) is a constant set to 0.9 and

\[ \beta = (\beta_1^2 - \beta_0^2)^{1/2}, \]

where \( \beta_1 \) is the full width at half-maximum (FWHM) of the observed diffraction line and \( \beta_0 \) is the FWHM of a diffraction line of a highly-crystalline reference material. The reference material used was Linde C alumina. \( \beta_0 \) was obtained by linear interpolation between the FWHM’s of reference diffraction lines whose \( \theta \)-values spanned that of the observed line.

Interpretation of XRD Results

Based on phase composition, the materials can be divided into three groups. Some were binary mixtures of W and W₂C; some were ternary mixtures of W, W₂C and W₃C; and still others were binary mixtures of W and W₂C. The crystallite sizes were uniformly small, almost always less than 20 nm (200Å) and often less than 10 nm (100Å).

Figure 11 is a Siemens CuKα scan of a W/W₂C/W₃C mixture. This pattern is rather more crystalline than the average, and shoes clearly that all three phases are present. Figure 12 is a Siemens CuKα scan of a ternary mixture, but in this case a trace amount of W₂C is present in the sample. Figure 13 is a Siemens CuKα scan of a ternary mixture and here a trace amount of W₂C is present in the sample. Figure 14 is a Siemens CrKα scan of a very low-crystalline, almost amorphous W/W₂C mixture. Figure 15 is a typical scan of a W/W₂C mixture. No W₃C was detected in this scan.

* PDF card 2-1138 is actually For W₂O. W₂C and W₃C are structurally isomorphous. To determine whether the coating consists of W + W₂C or W + W₂O, an Auger Emission Spectra (AES) depth profile was performed on a CVD produced tungsten/carbon alloy coating. Within the detection limits of the technique (>0.1 atomic percent) no oxygen was observed within the coating depth of ~360 nm (~3600Å) that was profiled. However, approximately 5.3 atomic percent carbon was observed within the depth profiled, indicating that the coating consisted of W + W₂C rather than W + W₂O.

<table>
<thead>
<tr>
<th>Substrate</th>
<th>Example 1</th>
<th>Example 2</th>
</tr>
</thead>
<tbody>
<tr>
<td></td>
<td>SIC-6</td>
<td>AM-350</td>
</tr>
<tr>
<td></td>
<td>Graphite</td>
<td>Stainless Steel</td>
</tr>
<tr>
<td>Temperature, °C</td>
<td>443</td>
<td>443</td>
</tr>
<tr>
<td>Pressure, Torr (1 Torr = 133.3 Pa)</td>
<td>40</td>
<td>40</td>
</tr>
<tr>
<td>Deposition Time, Min.</td>
<td>40</td>
<td>15</td>
</tr>
<tr>
<td>Flow Rates, Std. cc/min</td>
<td></td>
<td></td>
</tr>
<tr>
<td>WF₆</td>
<td>300</td>
<td>300</td>
</tr>
<tr>
<td>H₂</td>
<td>3,000</td>
<td>3,000</td>
</tr>
<tr>
<td>DME</td>
<td>--</td>
<td>--</td>
</tr>
<tr>
<td>Argon</td>
<td>--</td>
<td>4,000</td>
</tr>
<tr>
<td>H₂/WF₆ Ratio</td>
<td>10</td>
<td>10</td>
</tr>
<tr>
<td>WF₆/DME Ratio</td>
<td>--</td>
<td>--</td>
</tr>
<tr>
<td>DME partial pressure, Torr</td>
<td>--</td>
<td>--</td>
</tr>
<tr>
<td>W/C Atomic Ratio</td>
<td>--</td>
<td>--</td>
</tr>
<tr>
<td>Coating Thickness, μm</td>
<td>12-40</td>
<td>12-50</td>
</tr>
<tr>
<td>Vickers Hardness, Kg/mm²</td>
<td>510 ± 23</td>
<td>465 ± 49</td>
</tr>
</tbody>
</table>
Table 1
(continued)

Example 2

<table>
<thead>
<tr>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
</tr>
</thead>
<tbody>
<tr>
<td>Temperature, °C</td>
<td>440</td>
<td>442</td>
<td>447</td>
<td>443</td>
<td>443</td>
<td>443</td>
<td>431</td>
<td>371</td>
<td>445</td>
</tr>
<tr>
<td>Pressure, Torr</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
</tr>
<tr>
<td>(1 Torr = 133.3 Pa)</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>Deposition Time, Min.</td>
<td>40</td>
<td>30</td>
<td>35</td>
<td>30</td>
<td>30</td>
<td>30</td>
<td>30</td>
<td>20</td>
<td>40</td>
</tr>
<tr>
<td>Flow Rates, Std. cm³/min</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>WF₆</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>300</td>
</tr>
<tr>
<td>H₂</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
</tr>
<tr>
<td>DME</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>50</td>
<td>50</td>
<td>50</td>
<td>65</td>
<td>60</td>
</tr>
<tr>
<td>Argon</td>
<td>--</td>
<td>--</td>
<td>--</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>--</td>
</tr>
<tr>
<td>H₂/WF₆ Ratio</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>11</td>
</tr>
<tr>
<td>WF₆/DME Ratio</td>
<td>7.50</td>
<td>7.50</td>
<td>7.50</td>
<td>7.50</td>
<td>7.50</td>
<td>7.50</td>
<td>7.50</td>
<td>7.50</td>
<td>7.50</td>
</tr>
<tr>
<td>DME partial pressure, Torr.</td>
<td>0.48</td>
<td>0.48</td>
<td>0.48</td>
<td>0.33</td>
<td>0.44</td>
<td>0.55</td>
<td>0.55</td>
<td>0.55</td>
<td>0.66</td>
</tr>
<tr>
<td>W/C Atomic Ratio</td>
<td>3.75</td>
<td>3.75</td>
<td>3.75</td>
<td>5.00</td>
<td>3.75</td>
<td>3.00</td>
<td>3.00</td>
<td>2.69</td>
<td>2.50</td>
</tr>
<tr>
<td>Coating Thickness, μm</td>
<td>22</td>
<td>15</td>
<td>13</td>
<td>16</td>
<td>12</td>
<td>12</td>
<td>8</td>
<td>6</td>
<td>14</td>
</tr>
<tr>
<td>Vickers Hardness, Kg/mm²</td>
<td>--</td>
<td>--</td>
<td>--</td>
<td>2395±15</td>
<td>2470±53</td>
<td>2361±105</td>
<td>--</td>
<td>--</td>
<td>--</td>
</tr>
<tr>
<td>A</td>
<td>B</td>
<td>C</td>
<td>D</td>
<td>E</td>
<td>F</td>
<td>G</td>
<td>H</td>
<td>I</td>
<td>J</td>
</tr>
<tr>
<td>------</td>
<td>------</td>
<td>------</td>
<td>------</td>
<td>------</td>
<td>------</td>
<td>------</td>
<td>------</td>
<td>------</td>
<td>------</td>
</tr>
<tr>
<td>Graphite Graphite Graphite Graphite Graphite Graphite Graphite Graphite Graphite Graphite Graphite Graphite Graphite Graphite</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>Temperature, °C</td>
<td>445</td>
<td>443</td>
<td>443</td>
<td>443</td>
<td>451</td>
<td>462</td>
<td>462</td>
<td>462</td>
<td>467</td>
</tr>
<tr>
<td>Pressure, Torr (1 Torr = 133.3 Pa)</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>50</td>
</tr>
<tr>
<td>Deposition Time, Min.</td>
<td>20</td>
<td>15</td>
<td>40</td>
<td>20</td>
<td>20</td>
<td>35</td>
<td>40</td>
<td>40</td>
<td>40</td>
</tr>
<tr>
<td>Flow Rates, Std. cm³/min</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>WF₆</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>300</td>
</tr>
<tr>
<td>N₂</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
</tr>
<tr>
<td>DME</td>
<td>55</td>
<td>55</td>
<td>60</td>
<td>62</td>
<td>55</td>
<td>60</td>
<td>70</td>
<td>40</td>
<td>35</td>
</tr>
<tr>
<td>Argon</td>
<td>--</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>--</td>
<td>--</td>
<td>--</td>
<td>--</td>
<td>--</td>
</tr>
<tr>
<td>N₂/WF₆ Ratio</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>10</td>
</tr>
<tr>
<td>WF₆/DME Ratio</td>
<td>5.45</td>
<td>5.45</td>
<td>5.00</td>
<td>4.84</td>
<td>5.45</td>
<td>5.00</td>
<td>4.29</td>
<td>7.50</td>
<td>8.57</td>
</tr>
<tr>
<td>DME partial pressure, Torr</td>
<td>0.66</td>
<td>0.60</td>
<td>0.66</td>
<td>0.66</td>
<td>0.66</td>
<td>0.71</td>
<td>0.83</td>
<td>0.48</td>
<td>0.42</td>
</tr>
<tr>
<td>W/C Atomic Ratio</td>
<td>2.73</td>
<td>2.73</td>
<td>2.50</td>
<td>2.42</td>
<td>2.73</td>
<td>2.50</td>
<td>2.15</td>
<td>3.75</td>
<td>4.28</td>
</tr>
<tr>
<td>Coating Thickness, µm</td>
<td>8</td>
<td>5</td>
<td>12</td>
<td>5</td>
<td>13</td>
<td>15</td>
<td>13</td>
<td>22</td>
<td>21</td>
</tr>
<tr>
<td>Vickers Hardness, Kg/mm²</td>
<td>2248±70</td>
<td>2179±39</td>
<td>2224±46</td>
<td>--</td>
<td>2395±30</td>
<td>2414±69</td>
<td>2241±71</td>
<td>--</td>
<td>--</td>
</tr>
<tr>
<td>Substrate</td>
<td>A</td>
<td>B</td>
<td>C</td>
<td>D</td>
<td>E</td>
<td>F</td>
<td>G</td>
<td>H</td>
<td>I</td>
</tr>
<tr>
<td>-------------------</td>
<td>----</td>
<td>----</td>
<td>----</td>
<td>----</td>
<td>----</td>
<td>----</td>
<td>----</td>
<td>----</td>
<td>----</td>
</tr>
<tr>
<td>SIC-6</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>Graphite</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>Pressure, Torr</td>
<td>100</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
</tr>
<tr>
<td>(1 Torr = 133.3 Pa)</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>Deposition Time, Min.</td>
<td>15</td>
<td>50</td>
<td>35</td>
<td>20</td>
<td>20</td>
<td>70</td>
<td>30</td>
<td>40</td>
<td>40</td>
</tr>
<tr>
<td>Flow Rates, Std. cm³/min</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>WF₆</td>
<td></td>
<td>400</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>300</td>
</tr>
<tr>
<td>H₂</td>
<td>4,000</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
</tr>
<tr>
<td>DME</td>
<td></td>
<td>85</td>
<td>85</td>
<td>85</td>
<td>90</td>
<td>85</td>
<td>90</td>
<td>90</td>
<td>100</td>
</tr>
<tr>
<td>Argon</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>WF₆/H₂ Ratio</td>
<td></td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>10</td>
</tr>
<tr>
<td>DME partial pressure, Torr</td>
<td>1.45</td>
<td>1.00</td>
<td>1.00</td>
<td>0.97</td>
<td>0.97</td>
<td>1.00</td>
<td>0.97</td>
<td>0.97</td>
<td>1.08</td>
</tr>
<tr>
<td>W/C Atomic Ratio</td>
<td>3.08</td>
<td>1.76</td>
<td>1.76</td>
<td>1.76</td>
<td>1.67</td>
<td>1.76</td>
<td>1.67</td>
<td>1.67</td>
<td>1.50</td>
</tr>
<tr>
<td>Coating Thickness, µm</td>
<td></td>
<td>25</td>
<td>25</td>
<td>20</td>
<td>8</td>
<td>27</td>
<td>8</td>
<td>12</td>
<td>14</td>
</tr>
<tr>
<td>Vickers Hardness, Kg/mm²</td>
<td></td>
<td>2512±119</td>
<td>2758±77</td>
<td></td>
<td>2746±51</td>
<td></td>
<td>2758±31</td>
<td>2660±30</td>
<td>2851±66</td>
</tr>
</tbody>
</table>

Table 1 (continued)

Example 5
<table>
<thead>
<tr>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
</tr>
</thead>
<tbody>
<tr>
<td>Temperature, °C</td>
<td>431</td>
<td>454</td>
<td>454</td>
<td>442</td>
<td>434</td>
<td>421</td>
<td>443</td>
<td>445</td>
<td>445</td>
<td>445</td>
<td>445</td>
</tr>
<tr>
<td>Pressure, Torr</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
<td>40</td>
</tr>
<tr>
<td>(1 Torr = 133.3 Pa)</td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>Deposition Time, Min.</td>
<td>30</td>
<td>30</td>
<td>30</td>
<td>40</td>
<td>80</td>
<td>115</td>
<td>85</td>
<td>65</td>
<td>90</td>
<td>150</td>
<td>180</td>
</tr>
<tr>
<td>Flow Rates, Std. cm³/min</td>
<td>100</td>
<td>100</td>
<td>100</td>
<td>200</td>
<td>200</td>
<td>300</td>
<td>300</td>
<td>200</td>
<td>100</td>
<td>100</td>
<td>200</td>
</tr>
<tr>
<td>WF₆</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>200</td>
<td>100</td>
<td>100</td>
<td>200</td>
</tr>
<tr>
<td>H₂</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
<td>3,000</td>
<td>2,000</td>
<td>1,000</td>
<td>1,000</td>
<td>1,600</td>
</tr>
<tr>
<td>DME</td>
<td>90</td>
<td>90</td>
<td>90</td>
<td>90</td>
<td>90</td>
<td>90</td>
<td>90</td>
<td>60</td>
<td>30</td>
<td>30</td>
<td>60</td>
</tr>
<tr>
<td>Argon</td>
<td>300</td>
<td>300</td>
<td>300</td>
<td>1,500</td>
<td>1,500</td>
<td>1,800</td>
<td>1,500</td>
<td>1,800</td>
<td>3,000</td>
<td>5,000</td>
<td>4,000</td>
</tr>
<tr>
<td>H₂/WF₆ Ratio</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>10</td>
<td>8</td>
</tr>
<tr>
<td>WF₆/DME Ratio</td>
<td>3.33</td>
<td>4.29</td>
<td>3.33</td>
<td>3.33</td>
<td>3.33</td>
<td>3.33</td>
<td>3.33</td>
<td>3.33</td>
<td>3.33</td>
<td>3.33</td>
<td>3.33</td>
</tr>
<tr>
<td>DME partial pressure, Torr</td>
<td>0.97</td>
<td>0.76</td>
<td>0.97</td>
<td>0.74</td>
<td>0.74</td>
<td>0.69</td>
<td>0.74</td>
<td>0.69</td>
<td>0.42</td>
<td>0.19</td>
<td>0.41</td>
</tr>
<tr>
<td>W/C Atomic Ratio</td>
<td>1.67</td>
<td>2.15</td>
<td>1.67</td>
<td>1.67</td>
<td>1.67</td>
<td>1.67</td>
<td>1.67</td>
<td>1.67</td>
<td>1.67</td>
<td>1.67</td>
<td>1.67</td>
</tr>
<tr>
<td>Coating Thickness, µm</td>
<td>6.4</td>
<td>8</td>
<td>3</td>
<td>6</td>
<td>13</td>
<td>17</td>
<td>19</td>
<td>13</td>
<td>9</td>
<td>9</td>
<td>9</td>
</tr>
<tr>
<td>Vickers Hardness, Kg/mm²</td>
<td>2897±15</td>
<td>3210±15</td>
<td>--</td>
<td>--</td>
<td>2469±53</td>
<td>2470±53</td>
<td>2472±110</td>
<td>2398±109</td>
<td>2.035</td>
<td>2.315</td>
<td>2.167</td>
</tr>
<tr>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td>2.100</td>
</tr>
</tbody>
</table>
### Table 2

**Coating Composition**

<table>
<thead>
<tr>
<th></th>
<th>Example 1</th>
<th>Example 2</th>
<th>Example 3</th>
</tr>
</thead>
<tbody>
<tr>
<td><strong>Composition</strong></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>W</td>
<td>Major</td>
<td>Major</td>
<td>Minor</td>
</tr>
<tr>
<td>W₂C</td>
<td>None</td>
<td>None</td>
<td>None</td>
</tr>
<tr>
<td>W₃C</td>
<td>None</td>
<td>None</td>
<td>Major</td>
</tr>
<tr>
<td>Crystallite Size, Å (A ≈ 0.1mm)</td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>W</td>
<td>--</td>
<td>--</td>
<td>102</td>
</tr>
<tr>
<td>W₂C</td>
<td>--</td>
<td>--</td>
<td>140</td>
</tr>
<tr>
<td>W₃C</td>
<td>--</td>
<td>--</td>
<td>111</td>
</tr>
</tbody>
</table>

**Composition:** Concentration of W, W₂C, and W₃C in the coating is determined based upon relative peak intensities of W, W₂C, and W₃C phases.

**Terms:** In Table 2, the term "Major" denotes a phase concentration exceeding 30 weight percent; the term "Trace" denotes a phase concentration less than 5 weight percent; the term "Minor" denotes a phase concentration varying between 5 and 30 weight percent; the term "None" denotes not detected.
### Table 2 (continued)

Coating Composition

<table>
<thead>
<tr>
<th>Composition</th>
<th>A</th>
<th>B</th>
<th>C</th>
<th>D</th>
<th>E</th>
<th>F</th>
<th>G</th>
<th>H</th>
<th>I</th>
<th>J</th>
<th>K</th>
<th>L</th>
<th>M</th>
<th>N</th>
</tr>
</thead>
<tbody>
<tr>
<td>W</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
</tr>
<tr>
<td>W₂C</td>
<td>Major</td>
<td>Trace</td>
<td>Trace</td>
<td>Major</td>
<td>Trace</td>
<td>Minor</td>
<td>Major</td>
<td>Trace</td>
<td>Minor</td>
<td>Trace</td>
<td>Trace</td>
<td>Trace</td>
<td>Trace</td>
<td>Trace</td>
</tr>
<tr>
<td>W₃C</td>
<td>Major</td>
<td>Major</td>
<td>Minor</td>
<td>Major</td>
<td>Major</td>
<td>Trace</td>
<td>Major</td>
<td>Minor</td>
<td>Major</td>
<td>Minor</td>
<td>Minor</td>
<td>Minor</td>
<td>Minor</td>
<td>Minor</td>
</tr>
</tbody>
</table>

Crystallite Size, Å (1Å=100nm)

<table>
<thead>
<tr>
<th>Composition</th>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
<th></th>
</tr>
</thead>
<tbody>
<tr>
<td>W</td>
<td>--</td>
<td>--</td>
<td>80</td>
<td>138</td>
<td>--</td>
<td>164</td>
<td>150</td>
<td>--</td>
<td>--</td>
<td>--</td>
<td>--</td>
<td>100</td>
<td>128</td>
<td>134</td>
</tr>
<tr>
<td>W₂C</td>
<td>--</td>
<td>--</td>
<td>52</td>
<td>--</td>
<td>--</td>
<td>86</td>
<td>--</td>
<td>--</td>
<td>--</td>
<td>--</td>
<td>--</td>
<td>83</td>
<td>--</td>
<td>--</td>
</tr>
<tr>
<td>W₃C</td>
<td>--</td>
<td>--</td>
<td>--</td>
<td>107</td>
<td>--</td>
<td>73</td>
<td>120</td>
<td>--</td>
<td>--</td>
<td>--</td>
<td>--</td>
<td>48</td>
<td>74</td>
<td>74</td>
</tr>
</tbody>
</table>

Composition: Concentration of W, W₂C and W₃C in the coating is determined based upon relative peak intensities of W, W₂C and W₃C phases.

Terms: In Table 2, the term "Major" denotes a phase concentration exceeding 30 weight percent; the term "Trace" denotes a phase concentration less than 5 weight percent; the term "Minor" denotes a phase concentration varying between 5 and 30 weight percent; the term "None" denotes not detected.
### Table 2 (continued)

**Coating Composition**

<table>
<thead>
<tr>
<th></th>
<th>A</th>
<th>B</th>
<th>C</th>
<th>D</th>
<th>E</th>
<th>F</th>
<th>G</th>
<th>H</th>
<th>I</th>
<th>J</th>
<th>K</th>
<th>L</th>
</tr>
</thead>
<tbody>
<tr>
<td><strong>Composition</strong></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>W</td>
<td>Major</td>
<td>Minor</td>
<td>Minor</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td></td>
</tr>
<tr>
<td>W₂C</td>
<td>Minor</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td></td>
</tr>
<tr>
<td>W₃C</td>
<td>None</td>
<td>None</td>
<td>None</td>
<td>None</td>
<td>None</td>
<td>None</td>
<td>None</td>
<td>None</td>
<td>None</td>
<td>None</td>
<td>None</td>
<td>None</td>
</tr>
<tr>
<td><strong>Crystallite Size, Å (Å=100 nm)</strong></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>W</td>
<td>--</td>
<td>≤50</td>
<td>≤50</td>
<td>--</td>
<td>≤50</td>
<td>≤50</td>
<td>≤50</td>
<td>≤50</td>
<td>≤50</td>
<td>≤50</td>
<td>≤50</td>
<td>≤50</td>
</tr>
<tr>
<td>W₂C</td>
<td>--</td>
<td>≤50</td>
<td>≤50</td>
<td>--</td>
<td>≤50</td>
<td>≤50</td>
<td>≤50</td>
<td>≤50</td>
<td>≤50</td>
<td>≤50</td>
<td>≤50</td>
<td>≤50</td>
</tr>
<tr>
<td>W₃C</td>
<td>--</td>
<td>--</td>
<td>--</td>
<td>--</td>
<td>--</td>
<td>--</td>
<td>--</td>
<td>--</td>
<td>--</td>
<td>--</td>
<td>--</td>
<td>--</td>
</tr>
</tbody>
</table>

**Composition**: Concentration of W, W₂C and W₃C in the coating is determined based upon relative peak intensities of W, W₂C and W₃C phases.

**Terms**: In Table 2, the term "Major" denotes a phase concentration exceeding 30 weight percent; the term "Trace" denotes a phase concentration less than 5 weight percent; the term "Minor" denotes a phase concentration varying between 5 and 30 weight percent; the term "None" denotes not detected.
### Table 2
(continued)

**Coating Composition**

<table>
<thead>
<tr>
<th>Example 5</th>
<th>M</th>
<th>N</th>
<th>O</th>
<th>P</th>
<th>Q</th>
<th>R</th>
<th>S</th>
<th>T</th>
<th>U</th>
<th>V</th>
<th>W</th>
<th>X</th>
<th>Y</th>
<th>Z</th>
</tr>
</thead>
<tbody>
<tr>
<td><strong>Composition</strong></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>W</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
<td>Major</td>
</tr>
<tr>
<td>W₂C</td>
<td>Minor</td>
<td>Minor</td>
<td>Minor</td>
<td>Minor</td>
<td>Trace</td>
<td>Minor</td>
<td>Trace</td>
<td>Minor</td>
<td>Minor</td>
<td>Minor</td>
<td>Minor</td>
<td>Minor</td>
<td>Minor</td>
<td>Major</td>
</tr>
<tr>
<td>W₃C</td>
<td>None</td>
<td>None</td>
<td>None</td>
<td>None</td>
<td>None</td>
<td>None</td>
<td>None</td>
<td>None</td>
<td>None</td>
<td>None</td>
<td>None</td>
<td>None</td>
<td>None</td>
<td>None</td>
</tr>
</tbody>
</table>

**Crystallite Size, Å (Tₐ=100nm)**

<table>
<thead>
<tr>
<th></th>
<th>W</th>
<th>W₂C</th>
<th>W₃C</th>
</tr>
</thead>
<tbody>
<tr>
<td></td>
<td>83</td>
<td>58</td>
<td>--</td>
</tr>
<tr>
<td></td>
<td>50</td>
<td>50</td>
<td>50</td>
</tr>
<tr>
<td></td>
<td>50</td>
<td>50</td>
<td>50</td>
</tr>
<tr>
<td></td>
<td>50</td>
<td>50</td>
<td>50</td>
</tr>
<tr>
<td></td>
<td>50</td>
<td>50</td>
<td>50</td>
</tr>
<tr>
<td></td>
<td>50</td>
<td>50</td>
<td>50</td>
</tr>
<tr>
<td></td>
<td>50</td>
<td>50</td>
<td>50</td>
</tr>
<tr>
<td></td>
<td>50</td>
<td>50</td>
<td>50</td>
</tr>
<tr>
<td></td>
<td>50</td>
<td>50</td>
<td>50</td>
</tr>
<tr>
<td></td>
<td>50</td>
<td>50</td>
<td>50</td>
</tr>
<tr>
<td></td>
<td>50</td>
<td>50</td>
<td>50</td>
</tr>
<tr>
<td></td>
<td>50</td>
<td>50</td>
<td>50</td>
</tr>
</tbody>
</table>

---

**Composition:** Concentration of W, W₂C and W₃C in the coating is determined based upon relative peak intensities of W, W₂C and W₃C phases.

**Terms:** In Table 2, the term "Major" denotes a phase concentration exceeding 30 weight percent; the term "Trace" denotes a phase concentration less than 5 weight percent; the term "Minor" denotes a phase concentration varying between 5 and 30 weight percent; the term "None" denotes not detected.
<table>
<thead>
<tr>
<th>Parameter</th>
<th>Specification</th>
</tr>
</thead>
<tbody>
<tr>
<td>Nozzle Diameter</td>
<td>1.14mm (0.045 inch)</td>
</tr>
<tr>
<td>Stand Off Distance</td>
<td>12.7mm (0.5 inch)</td>
</tr>
<tr>
<td>Erosion Media</td>
<td>Crushed Glass (50 μm Average Particle Size)</td>
</tr>
<tr>
<td>Supply Pressure</td>
<td>4.12bar (45 psig)</td>
</tr>
<tr>
<td>Flow Rate of Erosion Media</td>
<td>1.0 g/min</td>
</tr>
<tr>
<td>Erosion Test Standard</td>
<td>Weight Loss in 10 Minutes</td>
</tr>
</tbody>
</table>
### Table 4

**Erosion Test Results**

<table>
<thead>
<tr>
<th>Coating Composition</th>
<th>Weight Loss, g</th>
<th>Calculated Volume Loss, cm³</th>
<th>Erosion Performance Relative to Uncoated AM-350 Stainless Steel</th>
</tr>
</thead>
<tbody>
<tr>
<td>Uncoated AM-350 Stainless Steel</td>
<td>N/A</td>
<td>0.00579</td>
<td>7.31x10⁻⁴</td>
</tr>
<tr>
<td>Coated AM-350 Stainless Steel</td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>Example 3C</td>
<td>W+WC</td>
<td>0.00042</td>
<td>2.63x10⁻⁵</td>
</tr>
<tr>
<td>Example 4F</td>
<td>W+W₂C+W₂C</td>
<td>0.00016</td>
<td>1.00x10⁻⁵</td>
</tr>
<tr>
<td>Example 5C</td>
<td>W+W₂C</td>
<td>0.00010</td>
<td>0.63x10⁻⁵</td>
</tr>
</tbody>
</table>

* (Weight loss) Uncoated specimen
  (Weight loss) Coated specimen

** (Volume loss) Uncoated specimen
  (Volume loss) Coated specimen
Thus it can be seen that the present invention discloses extremely hard, fine grained non-columnar tungsten-carbon alloys which consist essentially of a mixture of a substantially pure tungsten phase and at least one carbide phase wherein the carbide phase consists of W₂C or W₃C or a mixture of W₂C and W₃C. The new alloys are harder and more resistant to fracture, corrosion, erosion and wear than are tungsten-carbon alloys of the prior art that are produced by conventional chemical vapor deposition techniques and thus are composed of large columnar grains.

The present invention also discloses a method for producing the new tungsten-carbon alloys wherein the composition of the alloy's carbide phase can be controlled by controlling the temperature at which the reactions are run, the ratio of tungsten halide to oxygen- and hydrogen-containing organic compound and the ratio of hydrogen to tungsten halide. Thus the method makes it possible for those skilled in the art to produce custom alloys having desired carbide characteristics.

### Claims

1. A thermochemically deposited hard, fine-grained non-columnar tungsten-carbon alloy consisting essentially of a mixture of a substantially pure tungsten phase and W₂C, which product is in the form of fine, homogeneous and equiaxial grains having an average crystallite size of less than 0.1 micrometers; manifests when cross-sectioned and etched a lamellar appearance with layers less than 2 micrometers thick; and possesses a Vickers hardness greater than 1500.

2. An article comprising a substrate selected from metals, alloys, graphite, cemented carbides and ceramics and having thereon a coating of a product in accordance with claim 1.

3. An article according to claim 2 wherein said substrate is a metal or alloy which is reactive with process gases comprising (1) tungsten hexafluoride, (2) a volatile oxygen- and hydrogen-containing organic compound containing from one to four carbon atoms, and (3) hydrogen and wherein an interlayer of a
noble metal selected from the group consisting of nickel, cobalt, copper, silver, gold, platinum, rhodium, iridium and palladium is present between said substrate and said coating.

4. An article according to claim 2 wherein said substrate bears a chemical vapor deposited coating of substantially pure columnar tungsten which underlies said coating of a product in accordance with claim 1.

5. An article according to claim 4 wherein said substrate is a metal or alloy which is reactive with process gases comprising (1) tungsten hexafluoride and (2) hydrogen and wherein an interlayer of a noble metal selected from the group consisting of nickel, cobalt, copper, silver, gold, platinum, rhodium, iridium and palladium is present between said substrate and said columnar tungsten coating.

Patentansprüche

1. Thermochemisch abgeschiedene, harte, feinkörnige nicht säuleförmige Wolfram-Kohlenstoff-Legie-
run, die im wesentlichen aus einem Gemisch aus einer im wesentlichen reinen Wolfram-Phase und W₂C besteht, wobei das Produkt in Form von feinen, homogenen und gleichachsigen Körnern mit einer durchschnittlichen Kristallgröße von weniger als 0,1 Mikrometer vorliegt; die, wenn vernetzt und
geätzt, eine lamellare Erscheinungsform mit Schichten von weniger als 0,05 Mikromete Dicke zeigt; und
eine Vickers-Härte von mehr als 1500 besitzt.

2. Gegenstand, der ein aus Metallen, Legierungen, Graphit, cementierten Carbiden und Keramiken
ausgewähltes Substrat umfaßt und auf dem eine Beschichtung aus einem Produkt nach Anspruch 1 ist.

3. Gegenstand nach Anspruch 2, worin das Substrat ein Metall oder eine Legierung ist, die mit den
Prozeßgasen reagiert, welche (1) Wolframhexafluorid, (2) eine flüchtige sauerstoff- oder Wasserstoffhalti-
ge organisiche Verbindung mit einem bis vier Kohlenstoffatomen, und (3) Wasserstoff umfassen und
worin eine Zwischenschicht aus einem Edelmetall, ausgefällt aus der aus Nickel, Cobalt, Kupfer,
Silber, Gold, Platín, Rhodium, Iridium und Palladium bestehenden Gruppe, zwischen dem Substrat und
der Beschichtung vorliegt.

4. Gegenstand nach Anspruch 2, worin das Substrat eine chemisch abgeschiedene Beschichtung aus im
wesentlichen reinem säuleförmigen Wolfram trägt, das der Beschichtung aus einem Produkt nach
Anspruch 1 unterliegt.

5. Gegenstand nach Anspruch 4, worin das Substrat ein Metall oder eine Legierung ist, die mit den
Prozeßgasen reagiert, welche (1) Wolframhexafluorid und (2) Wasserstoff umfassen und worin eine
Zwischenschicht aus einem Edelmetall, ausgefällt aus der aus Nickel, Cobalt, Kupfer, Silber, Gold,
Platin, Rhodium, Iridium und Palladium bestehenden Gruppe, zwischen dem Substrat und der säule-
förmigen Wolfram-Beschichtung vorliegt.

Revendications

1. Alliage tungstène/carbonate de structure non basaltique ou non colonnaire, à graine fins, consistant
essentiellement en un mélange d’une phase tungstène sensiblement pure et de W₂C, lequel produit est
sous forme de grains fins homogènes et équiaux d’une taille de cristailler moyen inférieure à 0,1
micromètre, présente une apparence lamellaire lorsqu’il est coupé transversalement et attaqué à l’acide
avec des couches inférieures à 2μ d’épaisseur, et possède une dureté Vickers supérieure à 1500.

2. Article comprenant un substrat choisi parmi les métaux, les alliages, le graphite, les carbes cémentés
et céramiques et revêtu d’un produit selon la revendication 1.

3. Article selon la revendication 2, dans lequel le substrat est un métal ou un alliage qui est réactif aux
gaz de traitement comprenant (1) un hexafluorure de tungstène (2) un composé organique contenant
de l’oxygène volatile et de l’hydrogène contenant de 1 à 4 atomes de carbone, et (3) de l’hydrogène et
dans lequel une intercouche d’un métal précieux choisi parmi les groupes constitués par le nickel, le
cobalt, le cuivre, l’argent, l’or, le platine, le rhodium, l’iridium, le palladium est présent entre le substrat
de l’revêtement.
4. Article selon la revendication 2, dans lequel le substrat porte un revêtement déposé en phase gazeuse par procédé chimique de tungstène de structure basaltique ou colonnaire sensiblement pure qui se situe au-dessous du revêtement d'un produit selon la revendication 1.

5. Article selon la revendication 4, dans lequel le substrat est un métal ou un alliage qui est réactif aux gaz de traitement comprenant (1) un hexafluorure de tungstène, et (2) de l'hydrogène et dans lequel une intercouche d'un métal précieux choisi dans les groupes constitués par le nickel, le cobalt, le cuivre, l'argent, l'or, le platine, le rhodium, l'iridium et le palladium est présent entre le substrat et le revêtement de tungstène de structure basaltique ou colonnaire.
FIG. 8A

FIG. 8B